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(19) **United States**(12) **Patent Application Publication** (10) **Pub. No.: US 2004/0257488 A1****Lee et al.**(43) **Pub. Date: Dec. 23, 2004**(54) **LIQUID CRYSTAL DISPLAY AND THIN FILM TRANSISTOR ARRAY PANEL THEREFOR**(30) **Foreign Application Priority Data**

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Correspondence Address:

**McGuireWoods LLP****Suite 1800****1750 Tysons Boulevard****McLean, VA 22102 (US)**(21) Appl. No.: **10/813,304**(22) Filed: **Mar. 31, 2004**(57) **ABSTRACT**

A gate line extending in a transverse direction and a data line intersecting the gate line are formed on the substrate. A pixel electrode connected to the gate line and the data line through a thin film transistor is formed on an insulating layer. The pixel electrode has a cutout and a protrusion is disposed in the cutout. Another protrusion is disposed on the data line.

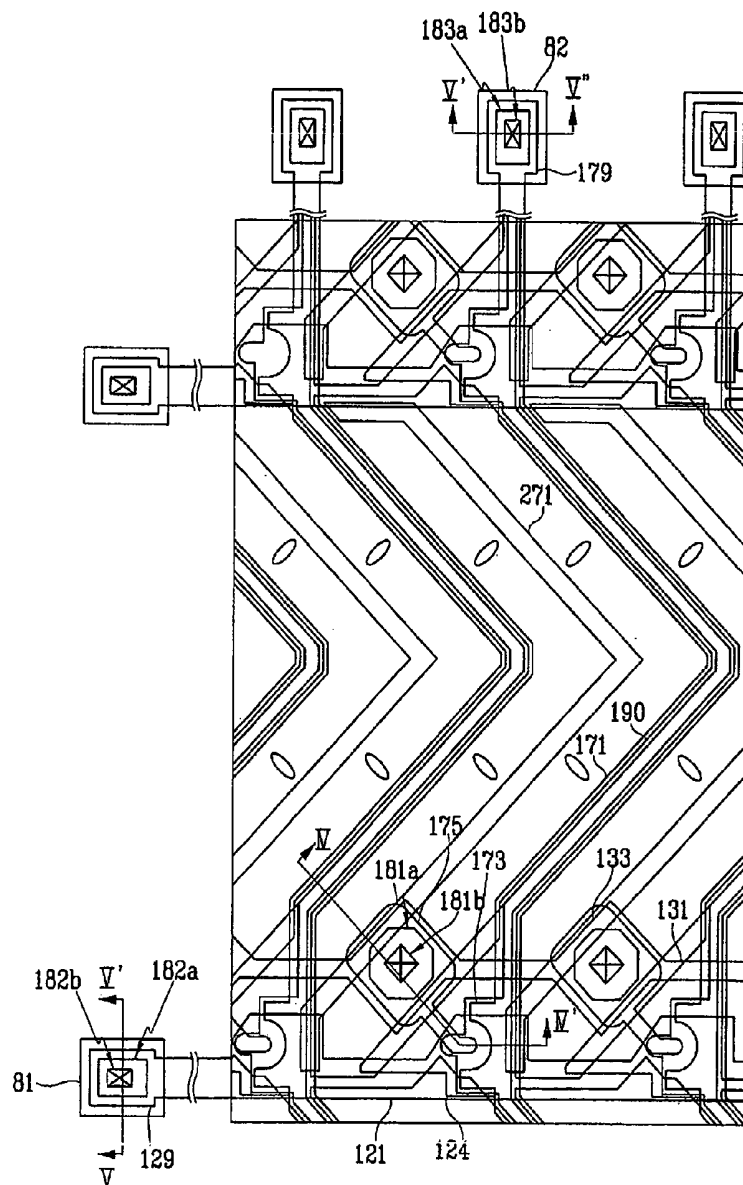


FIG. 1

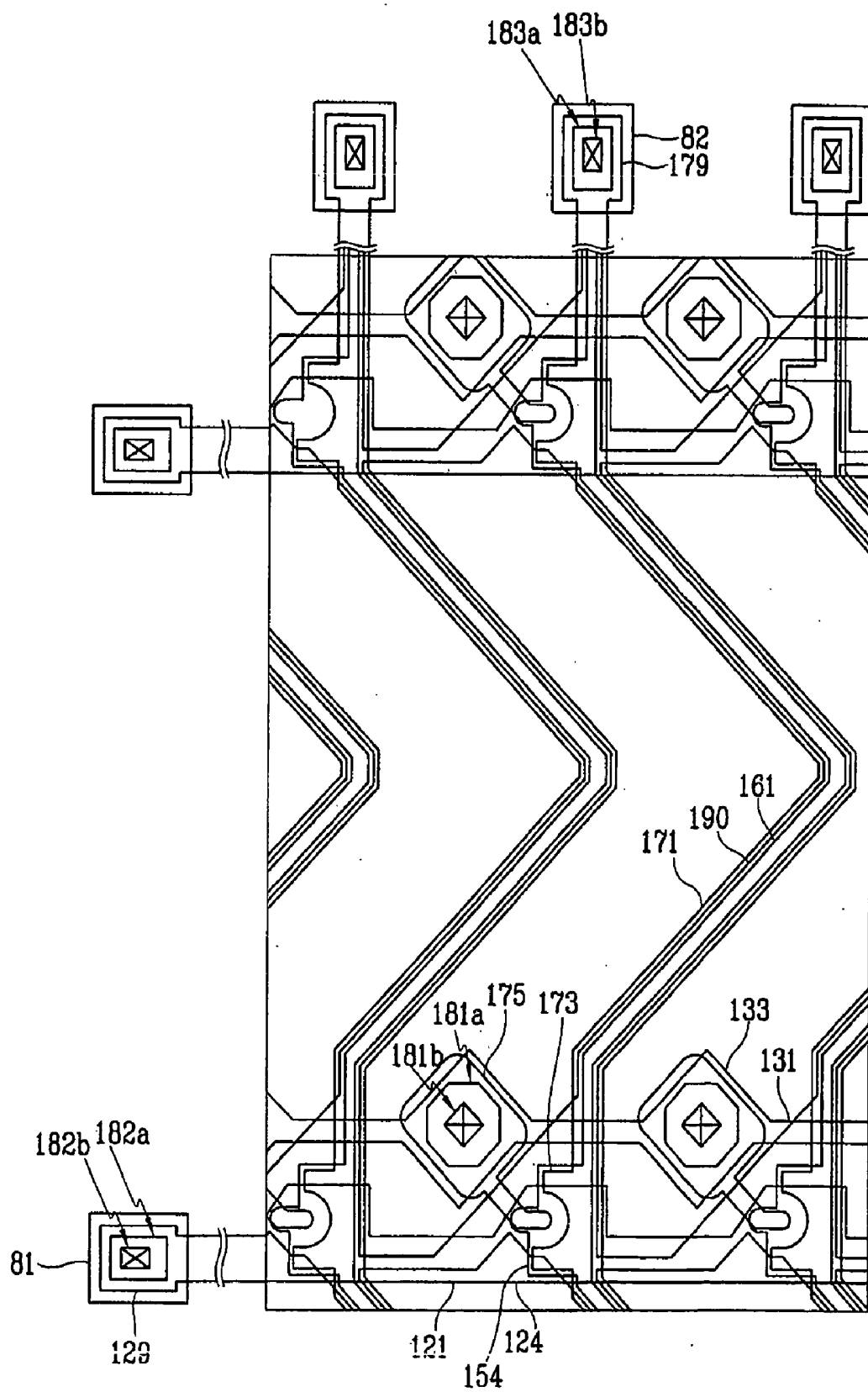


FIG.2

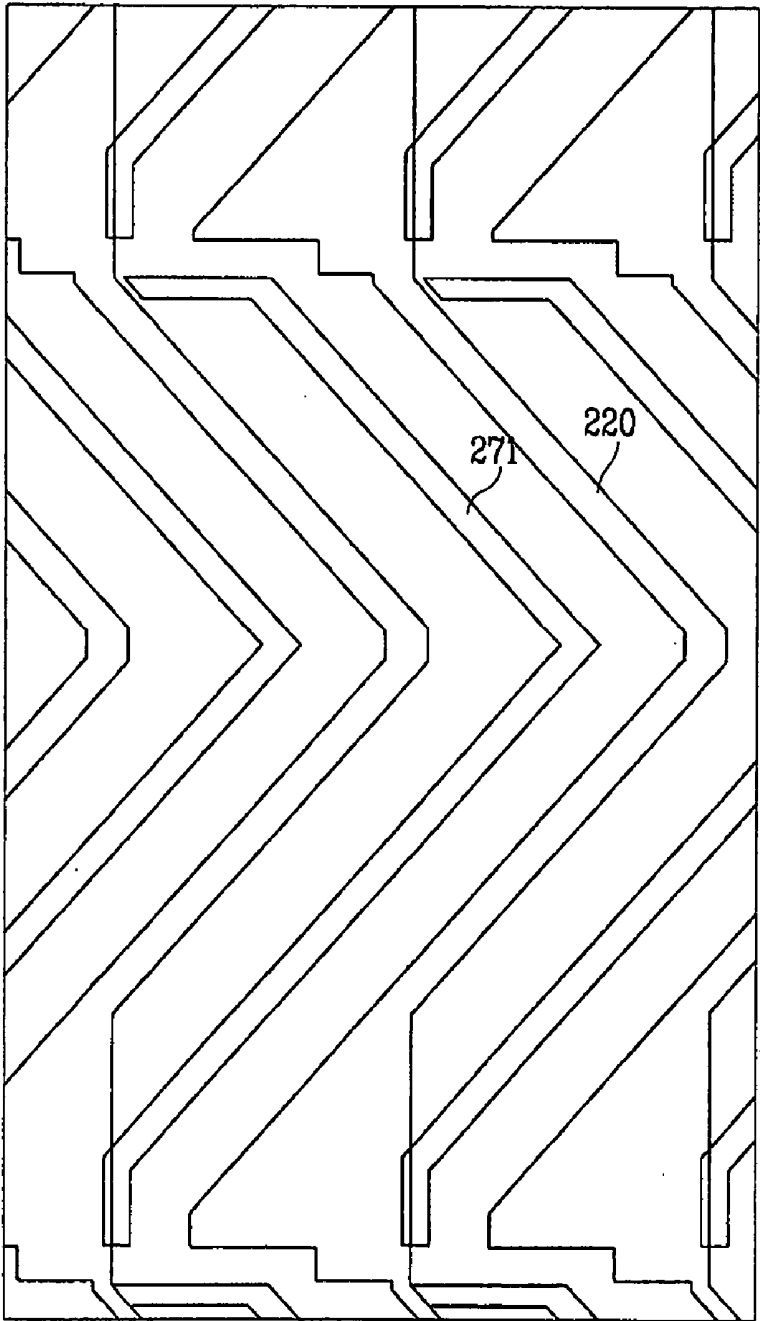


FIG.3

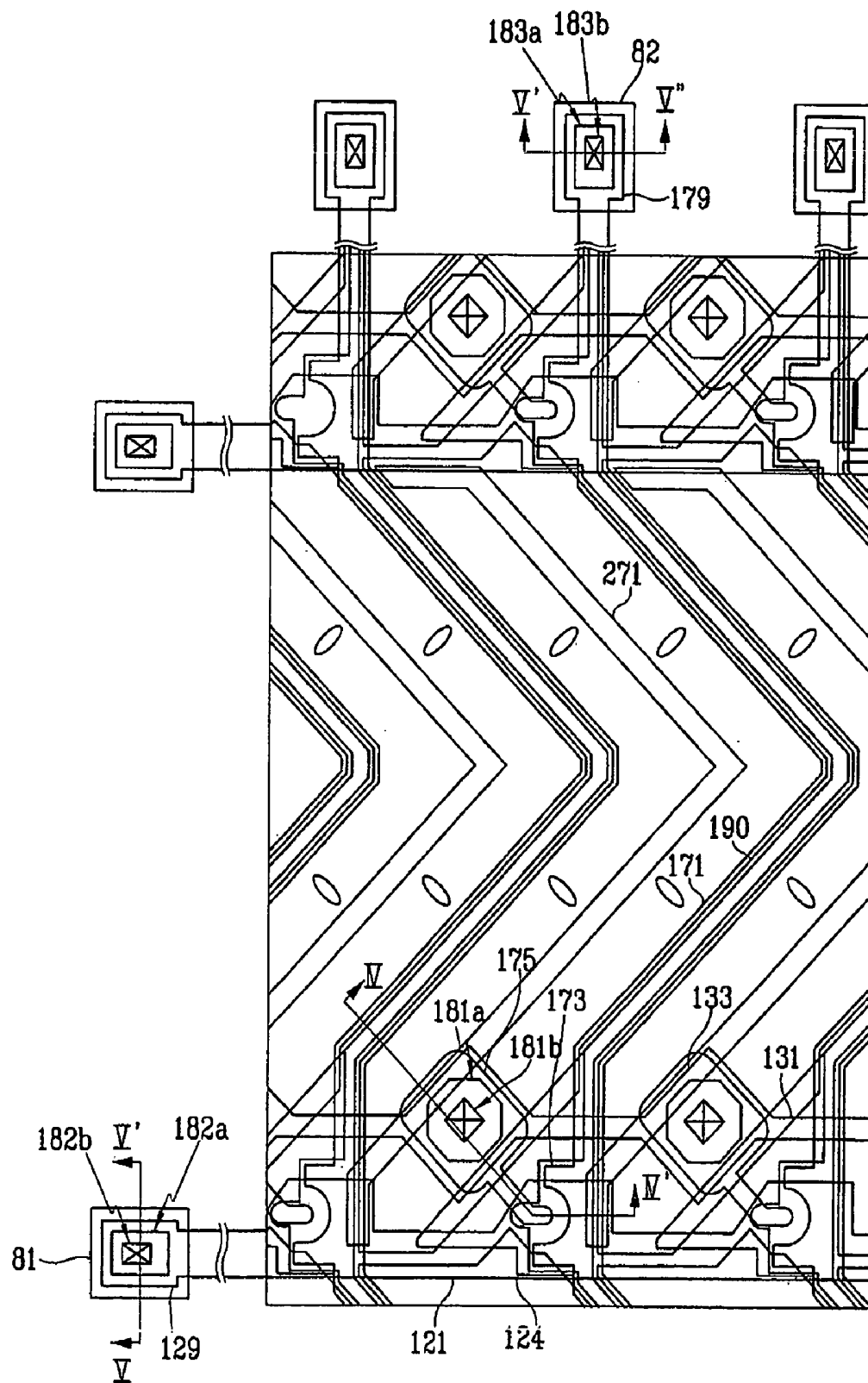


FIG.4

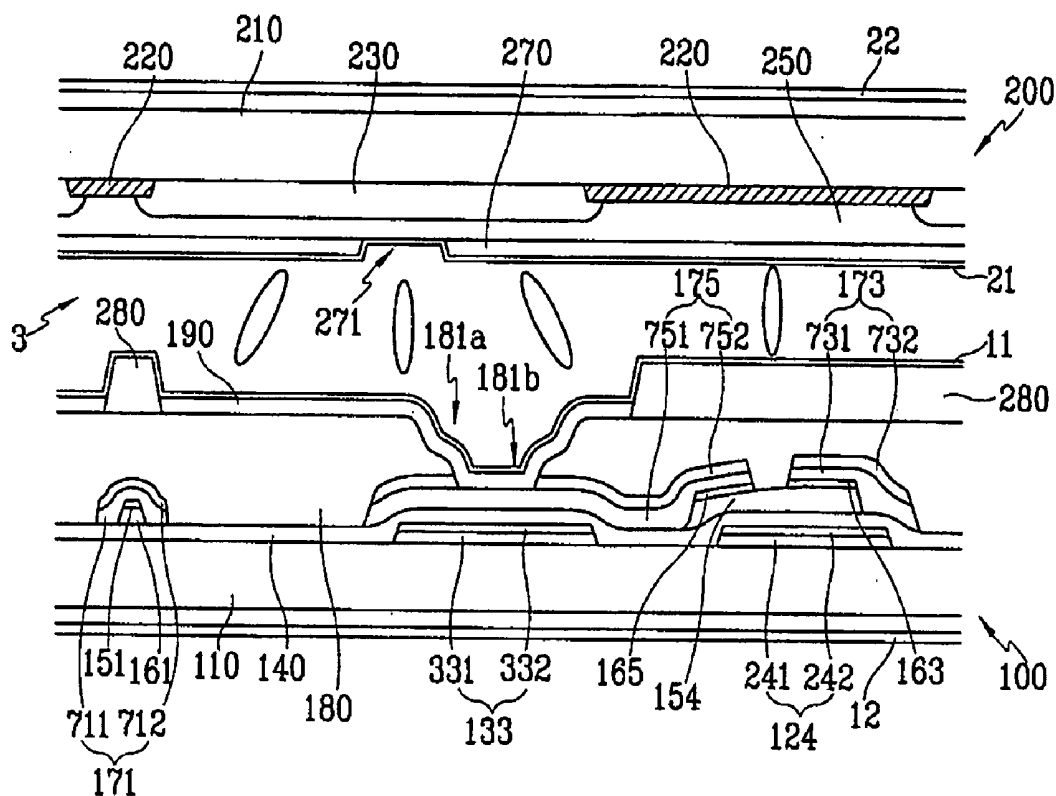


FIG.5

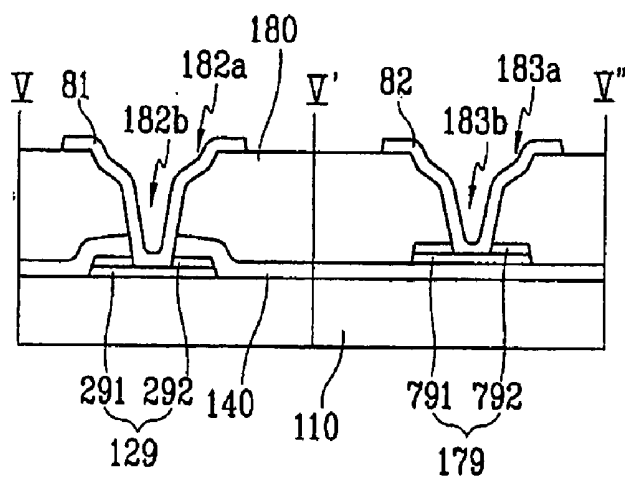


FIG.6A

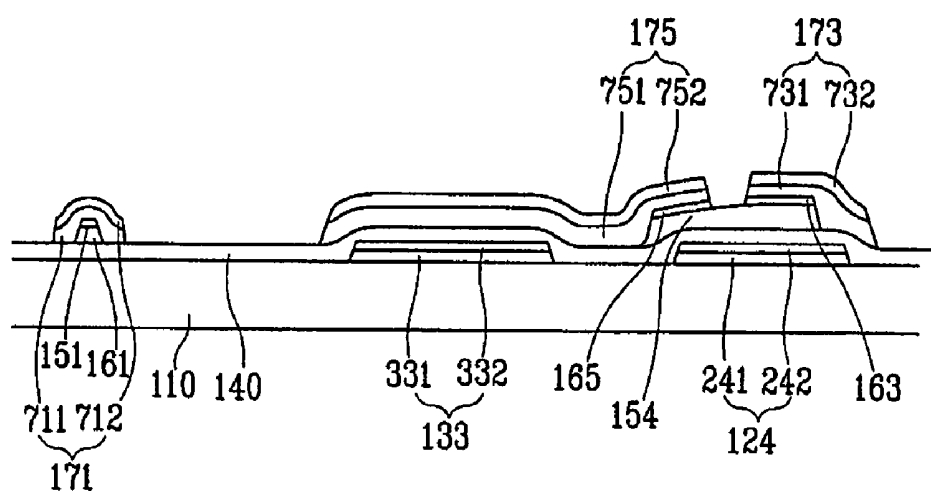


FIG.6B

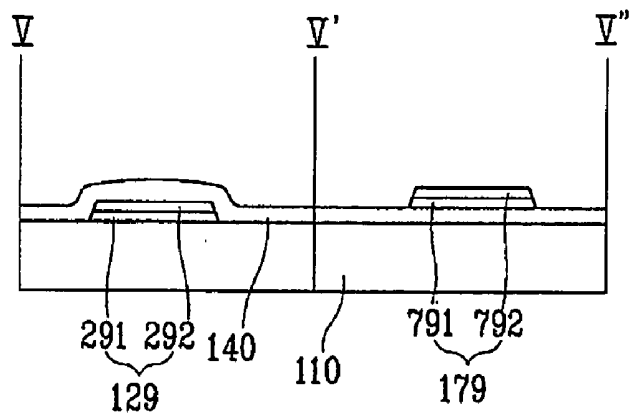


FIG. 7A

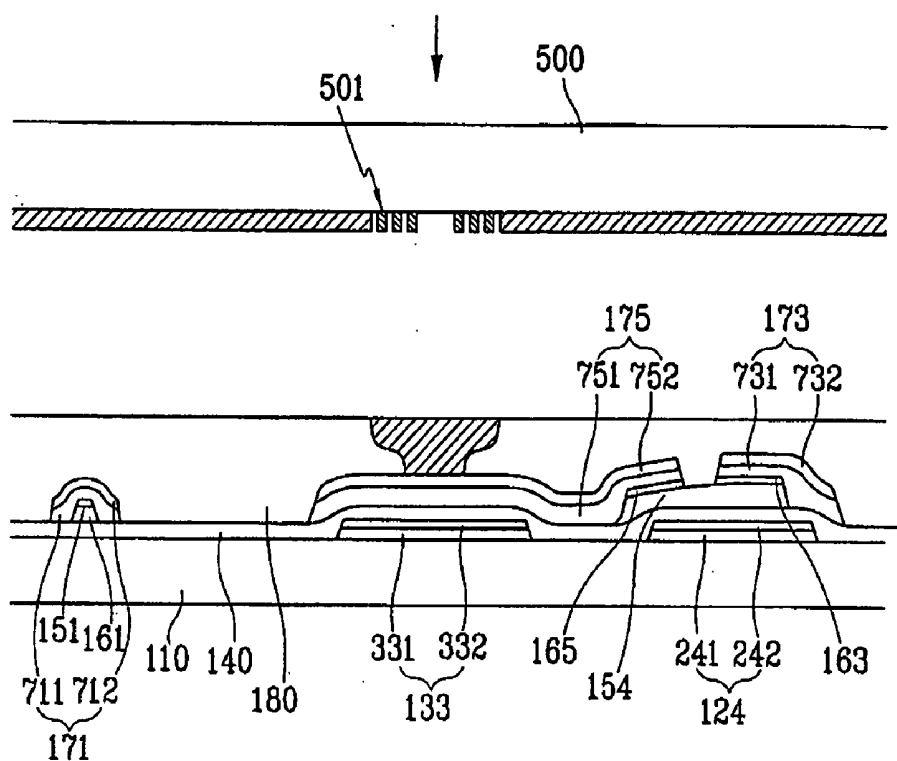


FIG. 7B

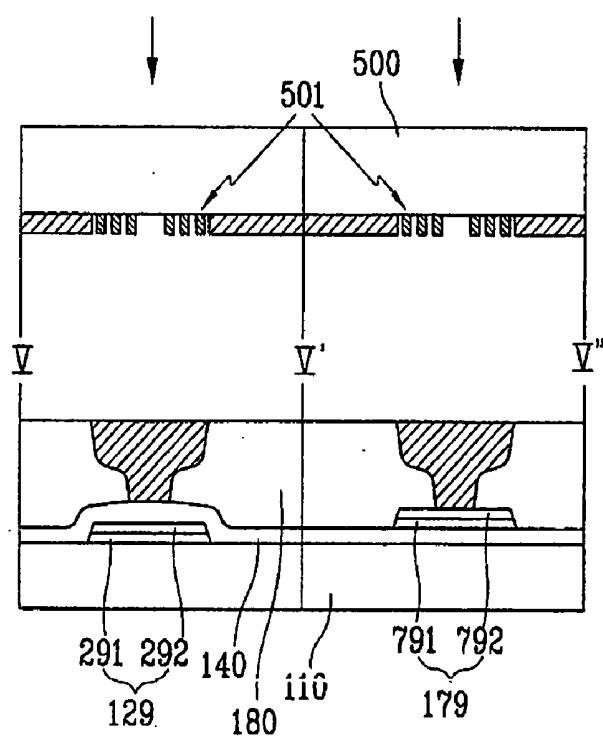






FIG.9

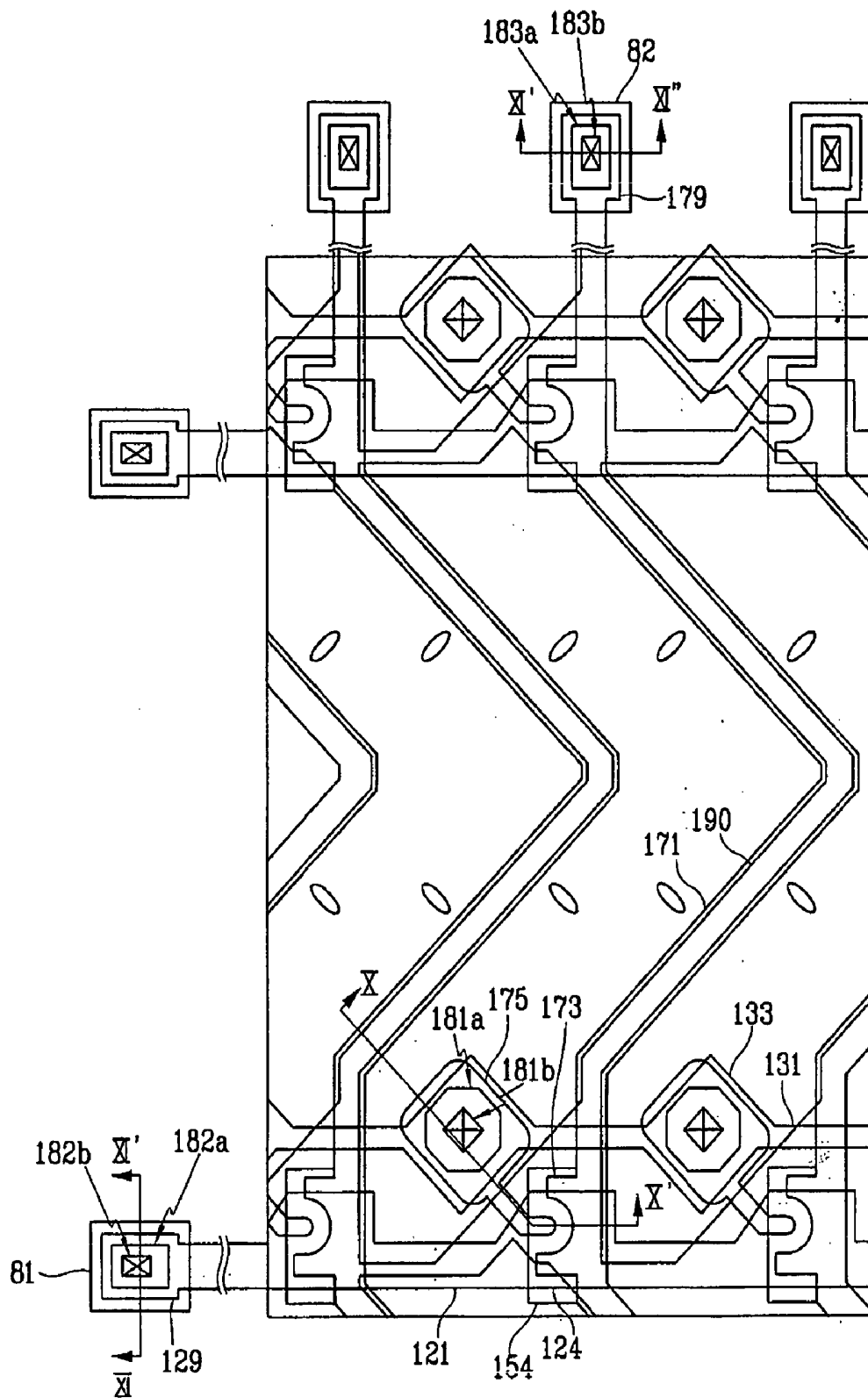


FIG.10

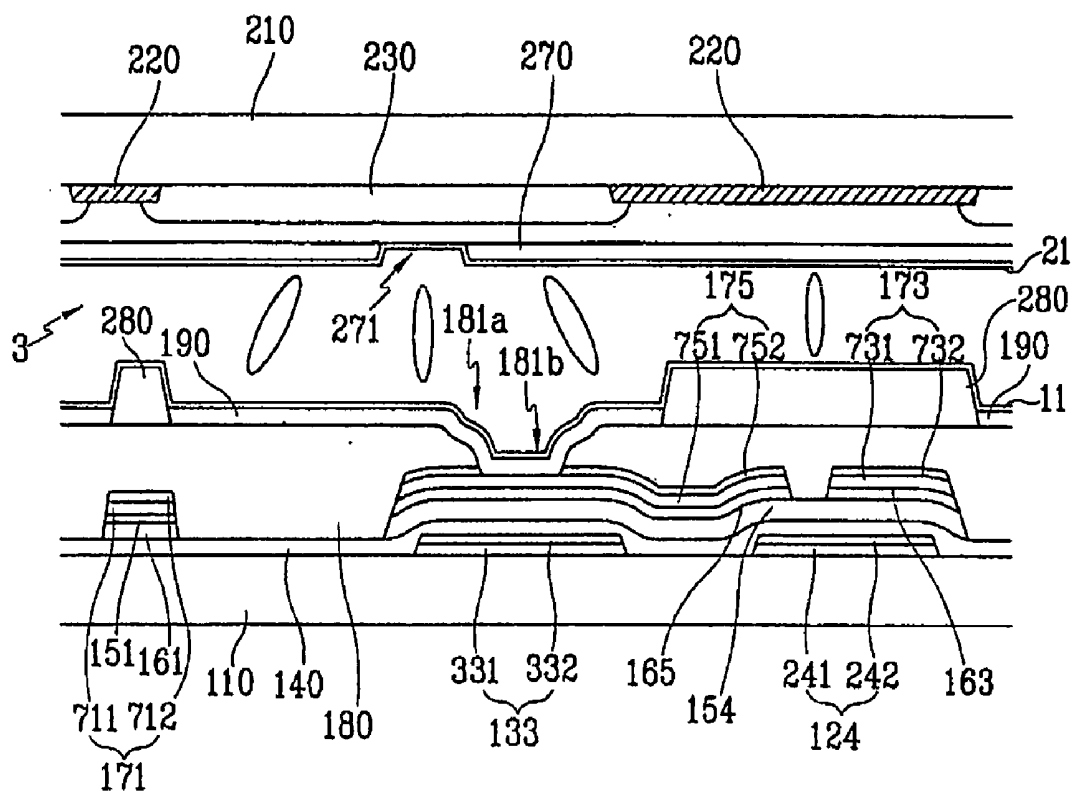


FIG.11

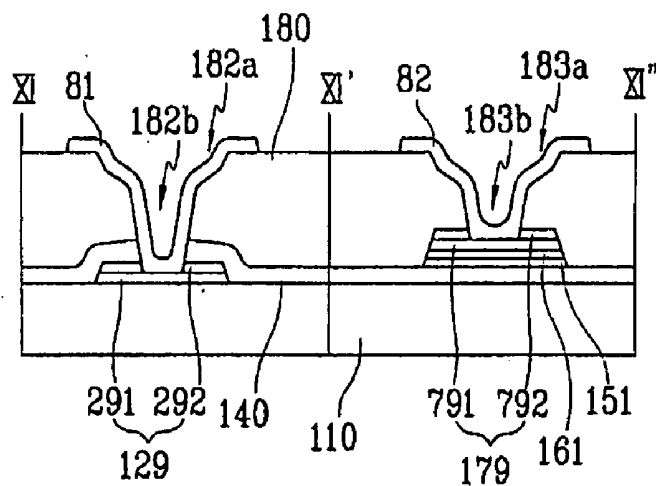


FIG.12A

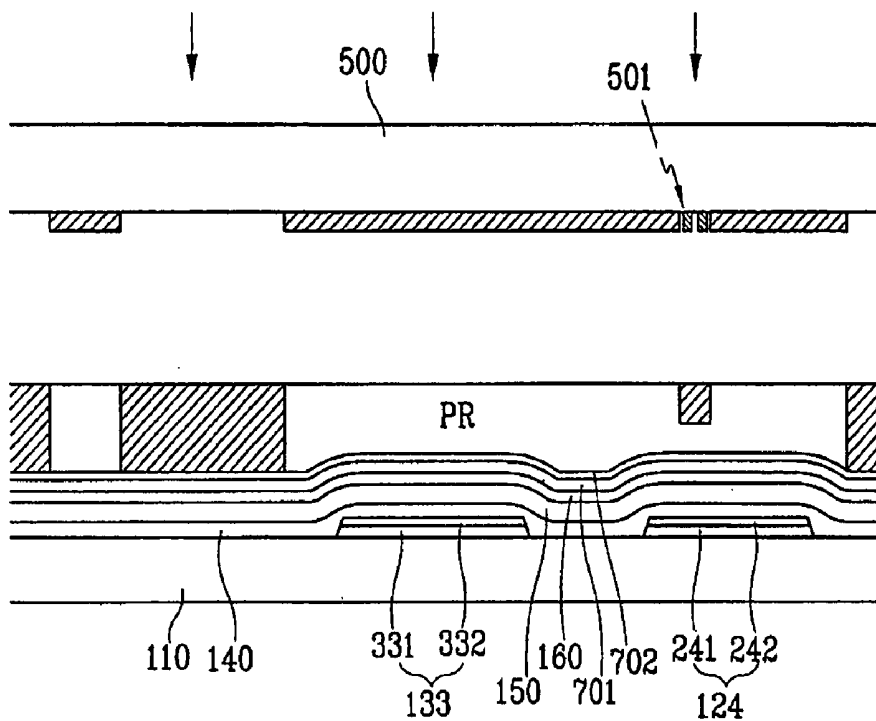


FIG.12B

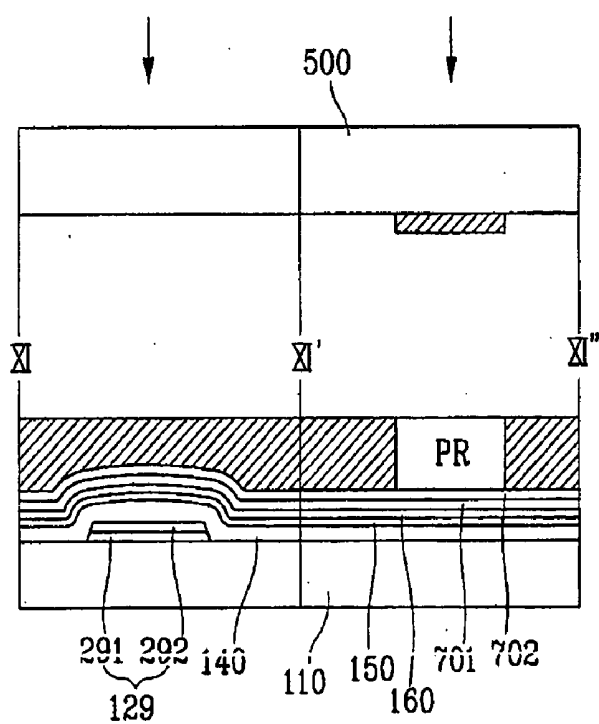


FIG.13A

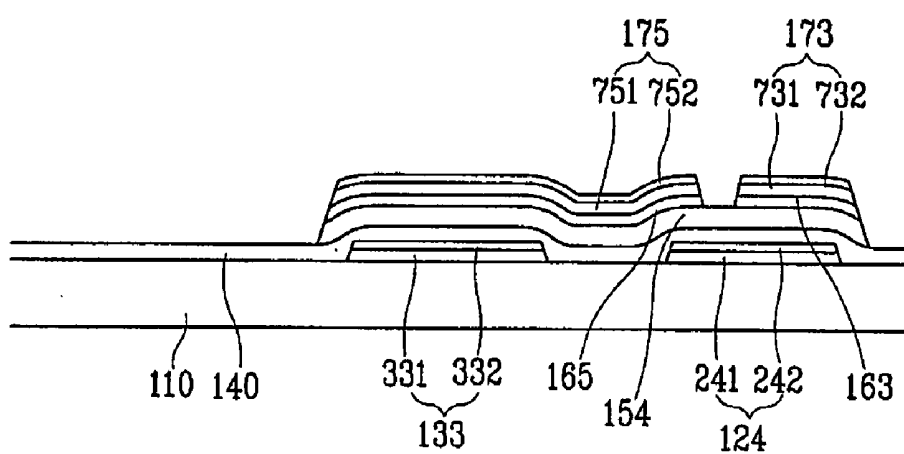


FIG.13B

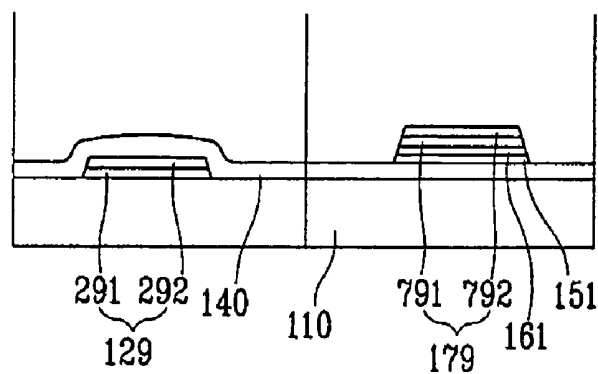


FIG.14A

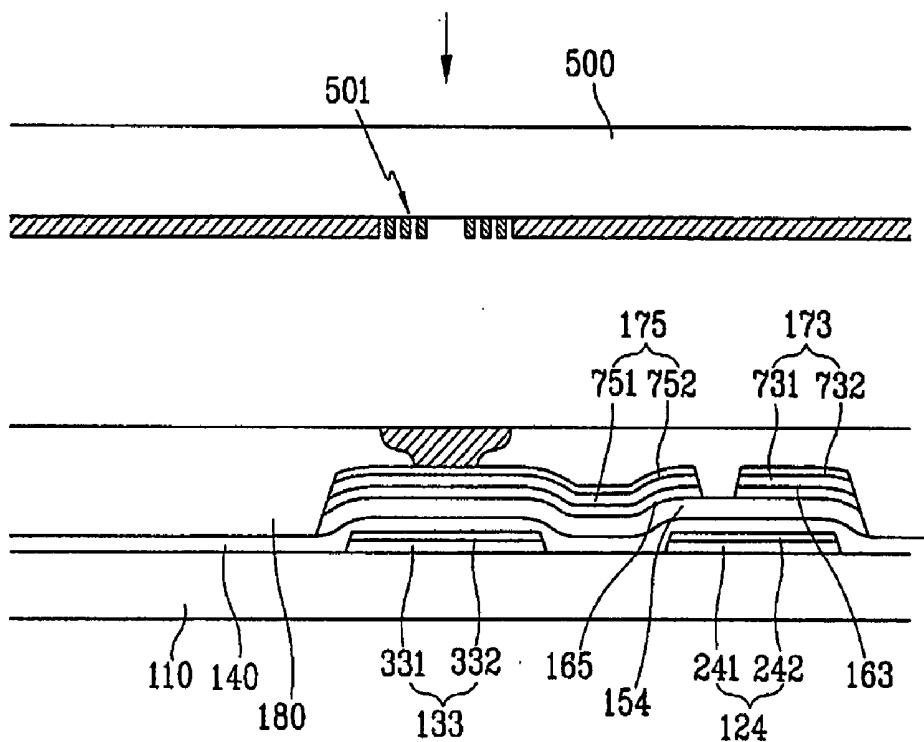


FIG.14B

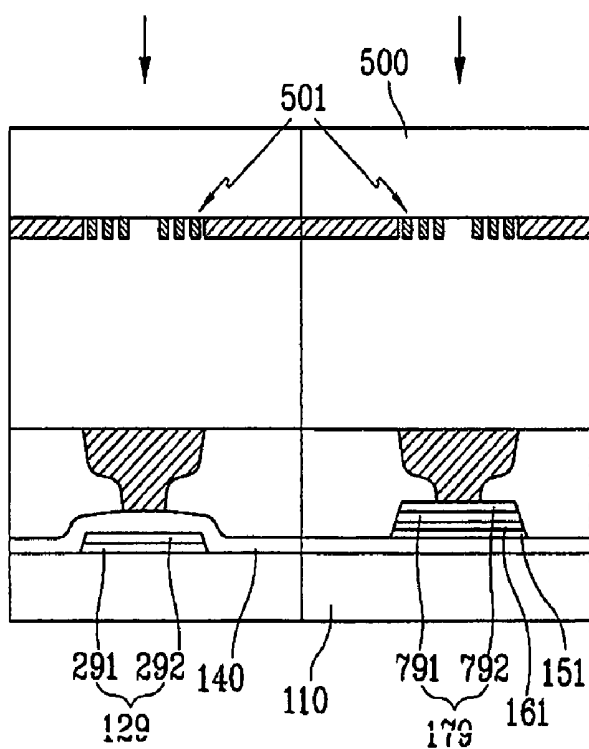


FIG.15A

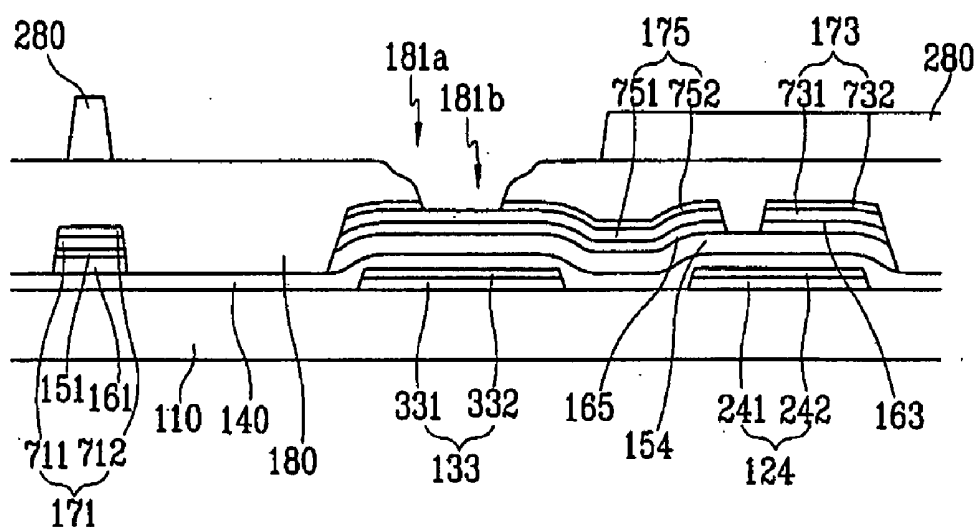


FIG.15B

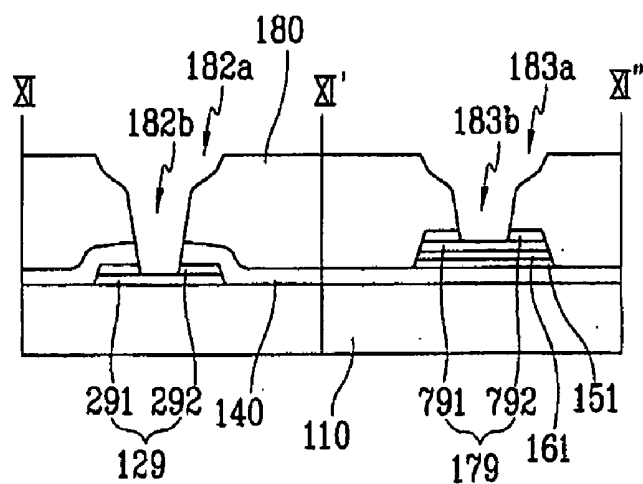


FIG.16

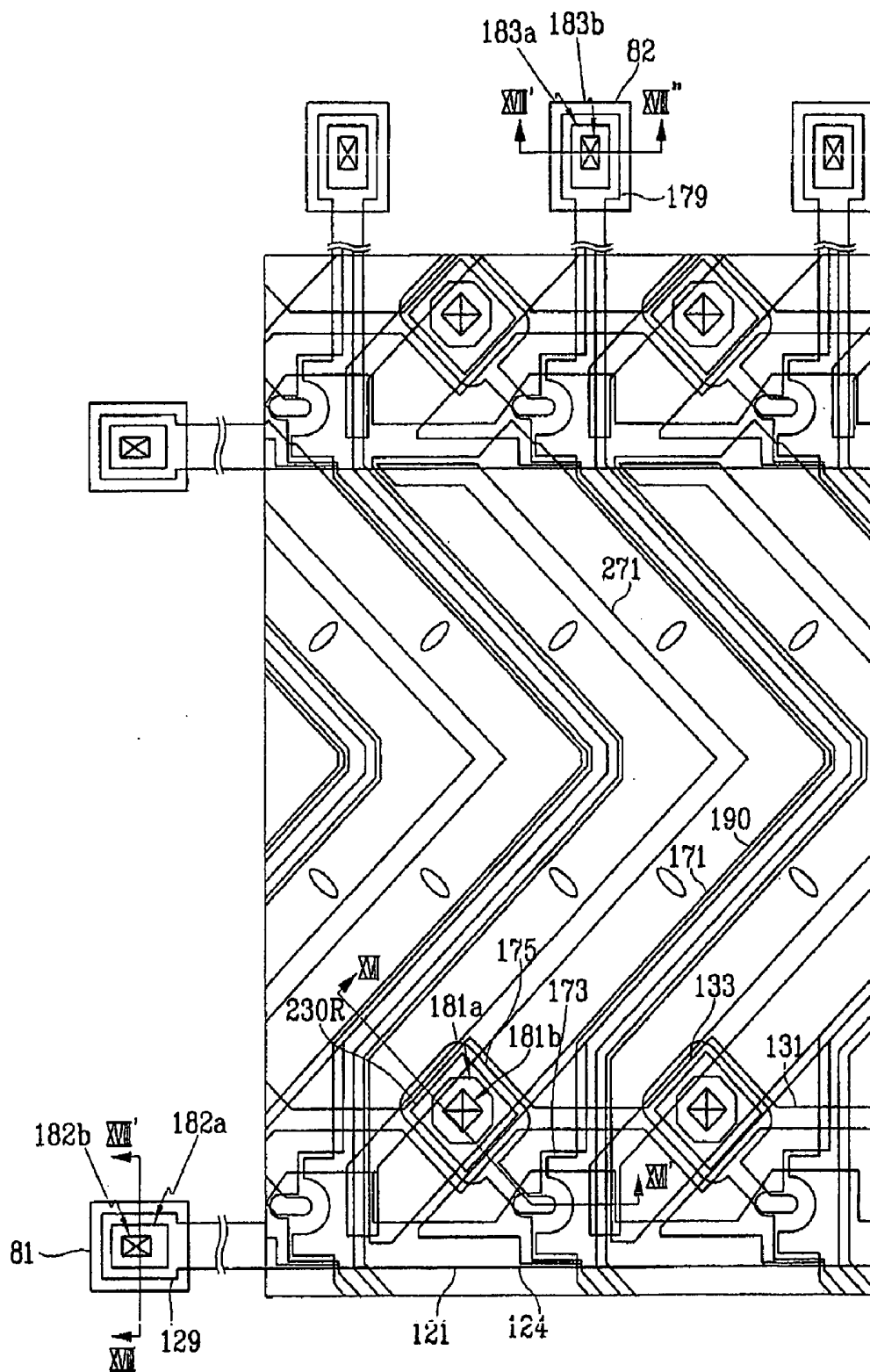


FIG.17

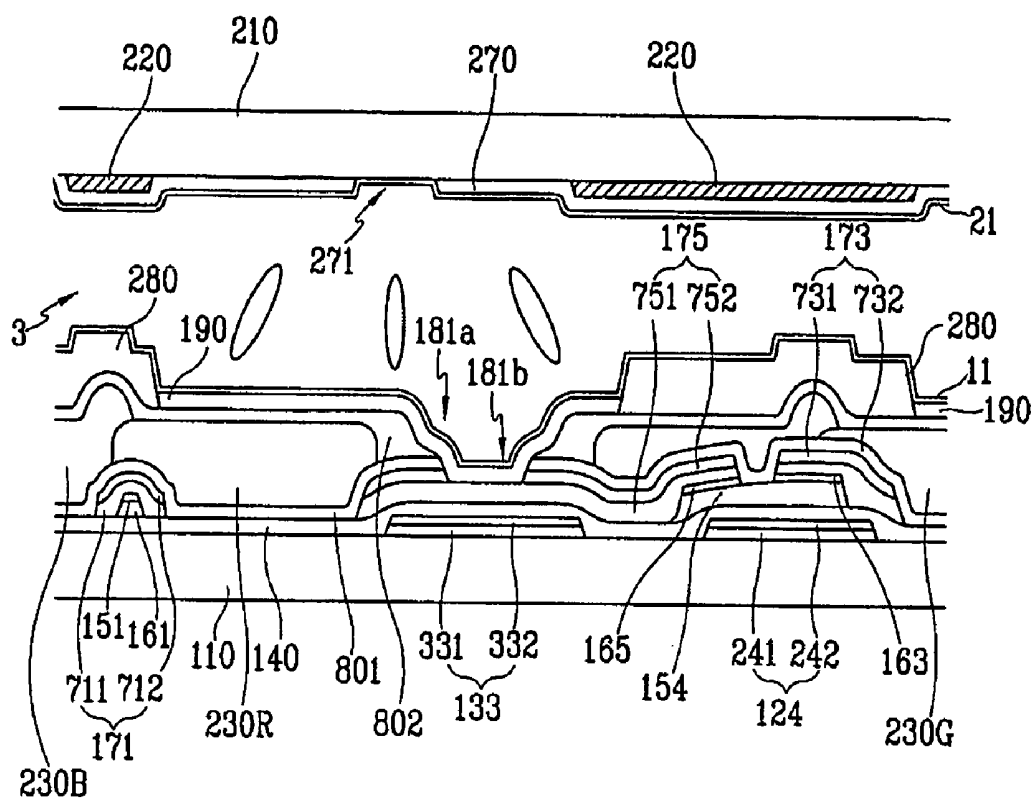


FIG.18

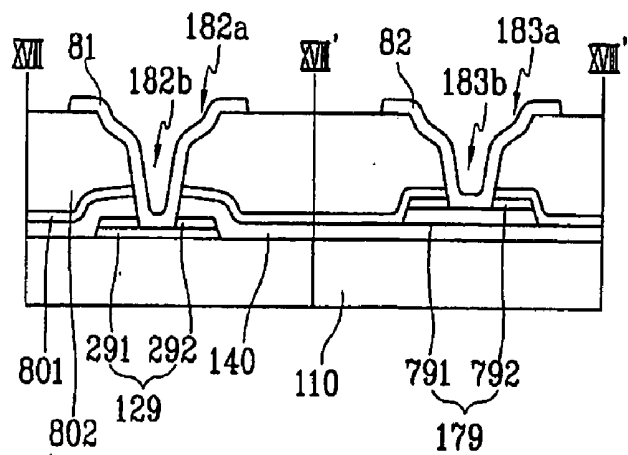




FIG.19

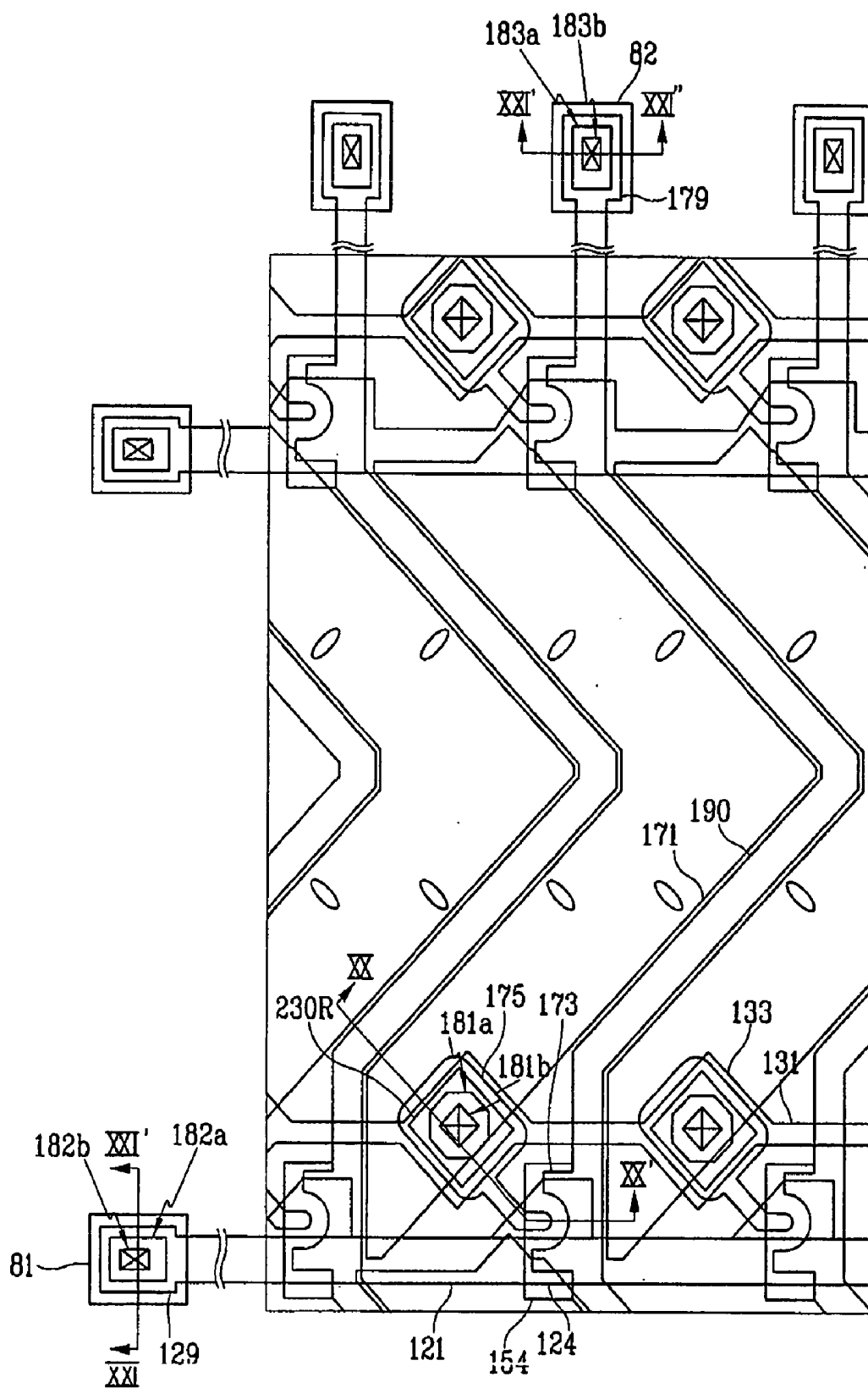


FIG.20

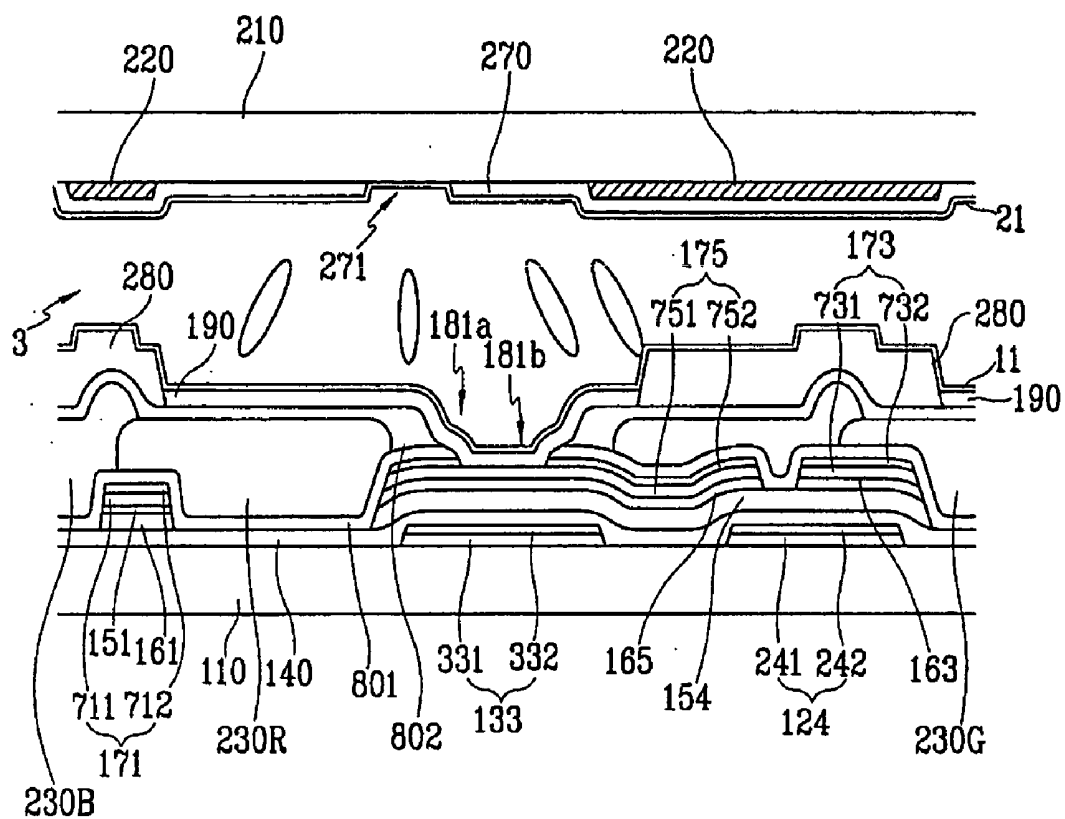


FIG.21

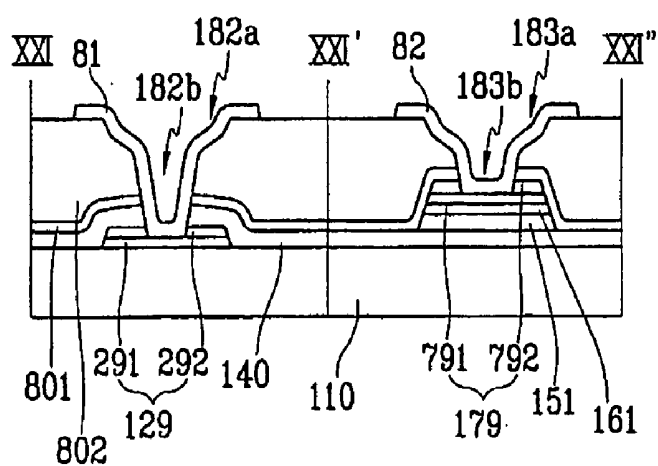


FIG.22

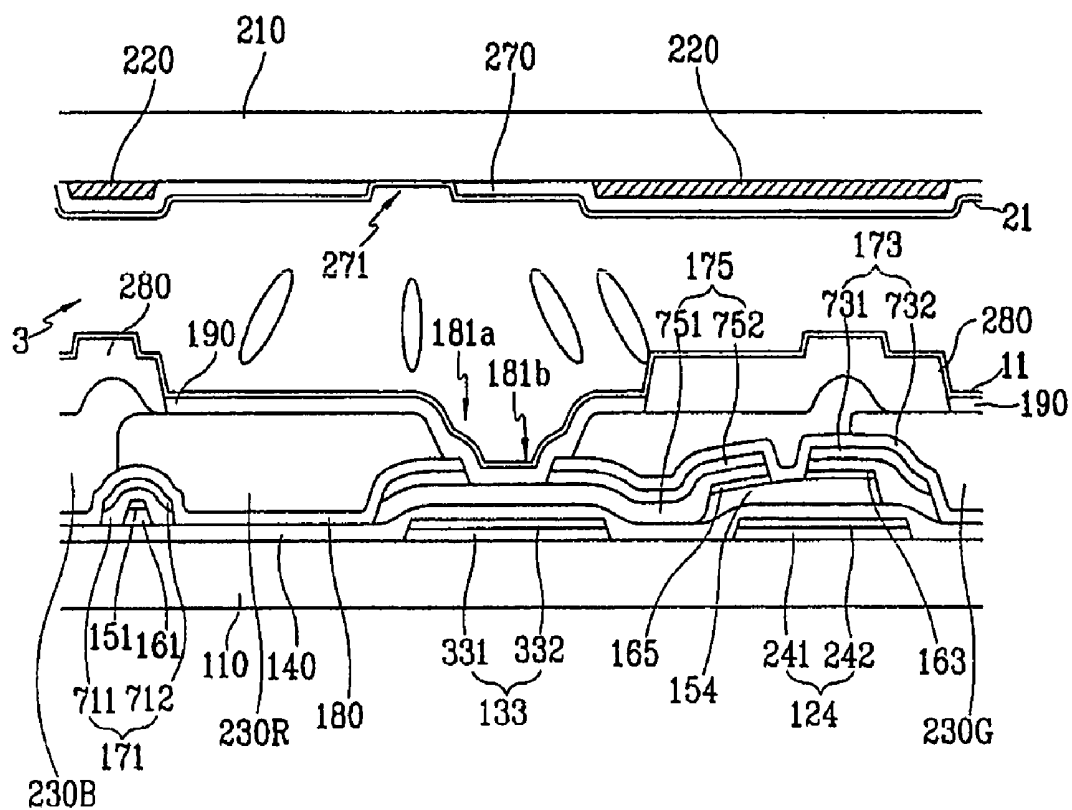


FIG.23

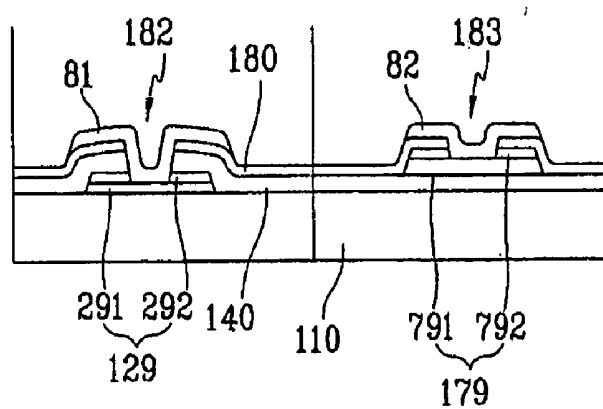


FIG.24

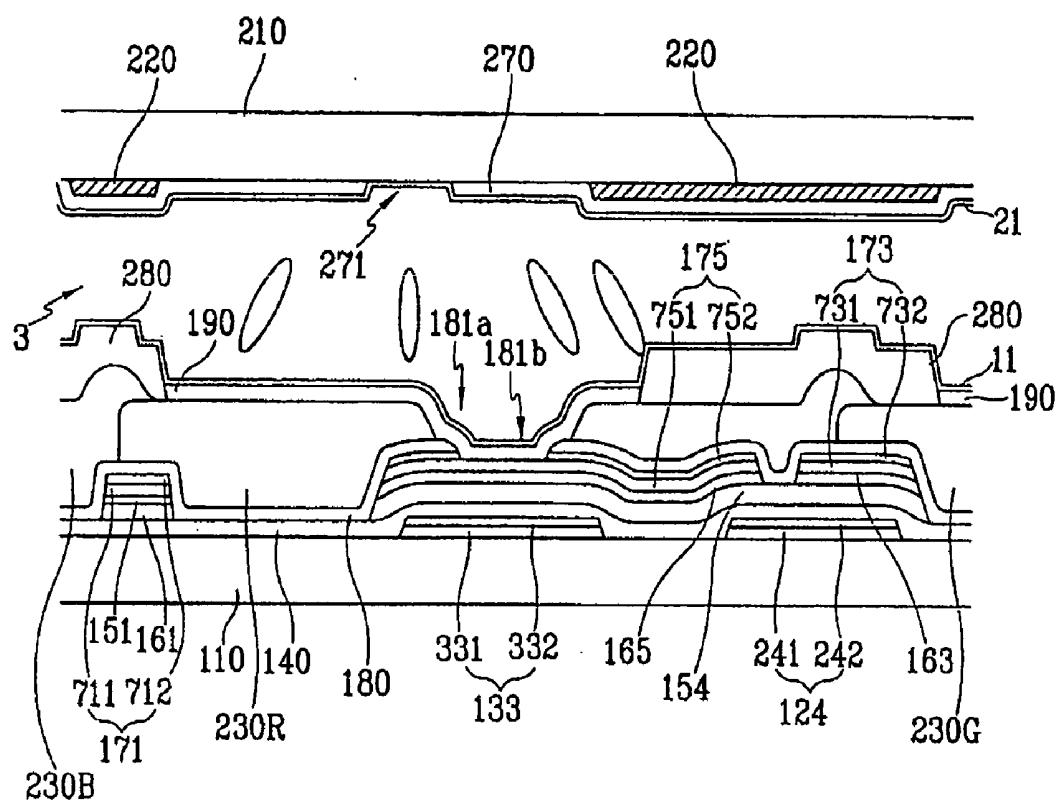


FIG.25

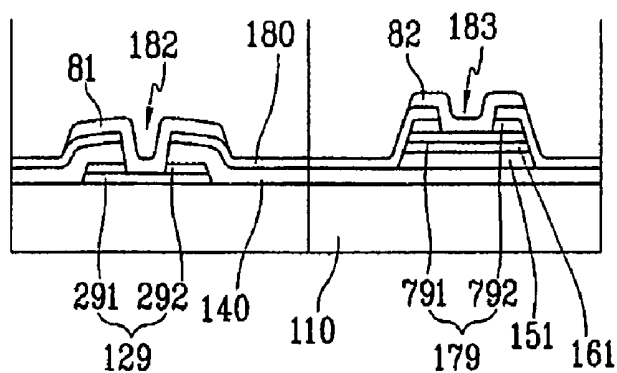




FIG.28

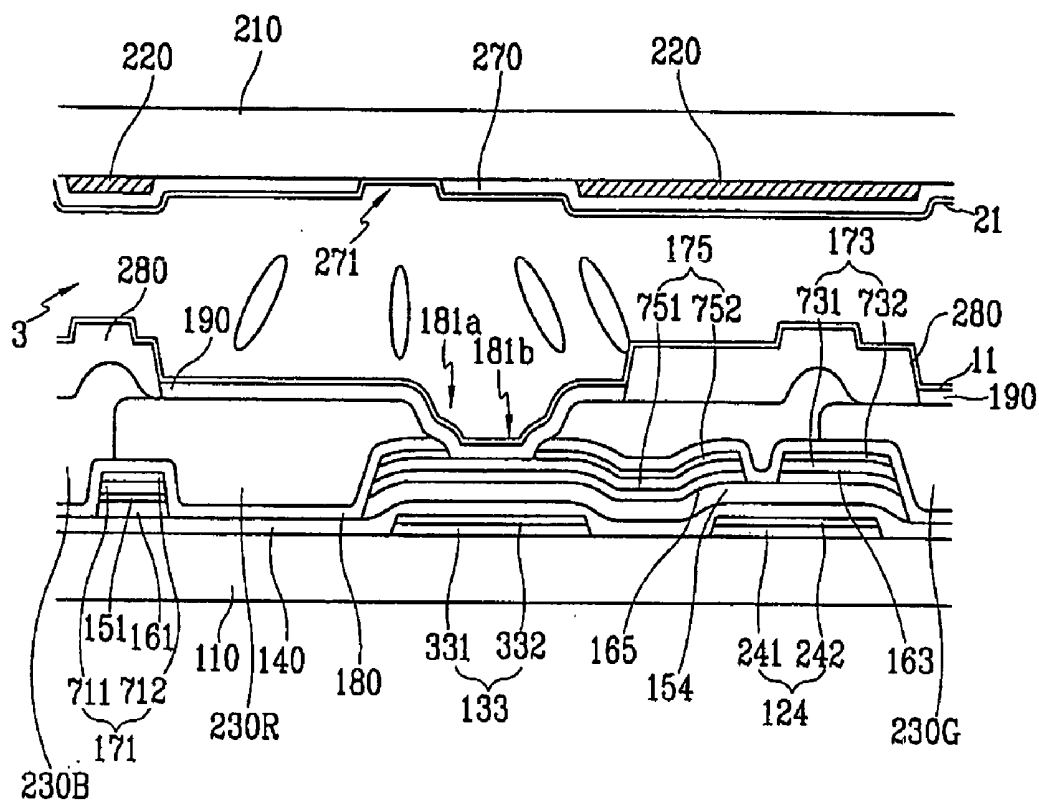


FIG.29

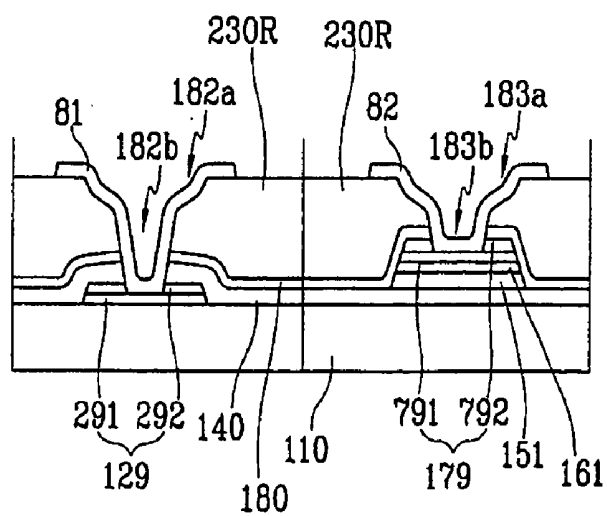


FIG.30

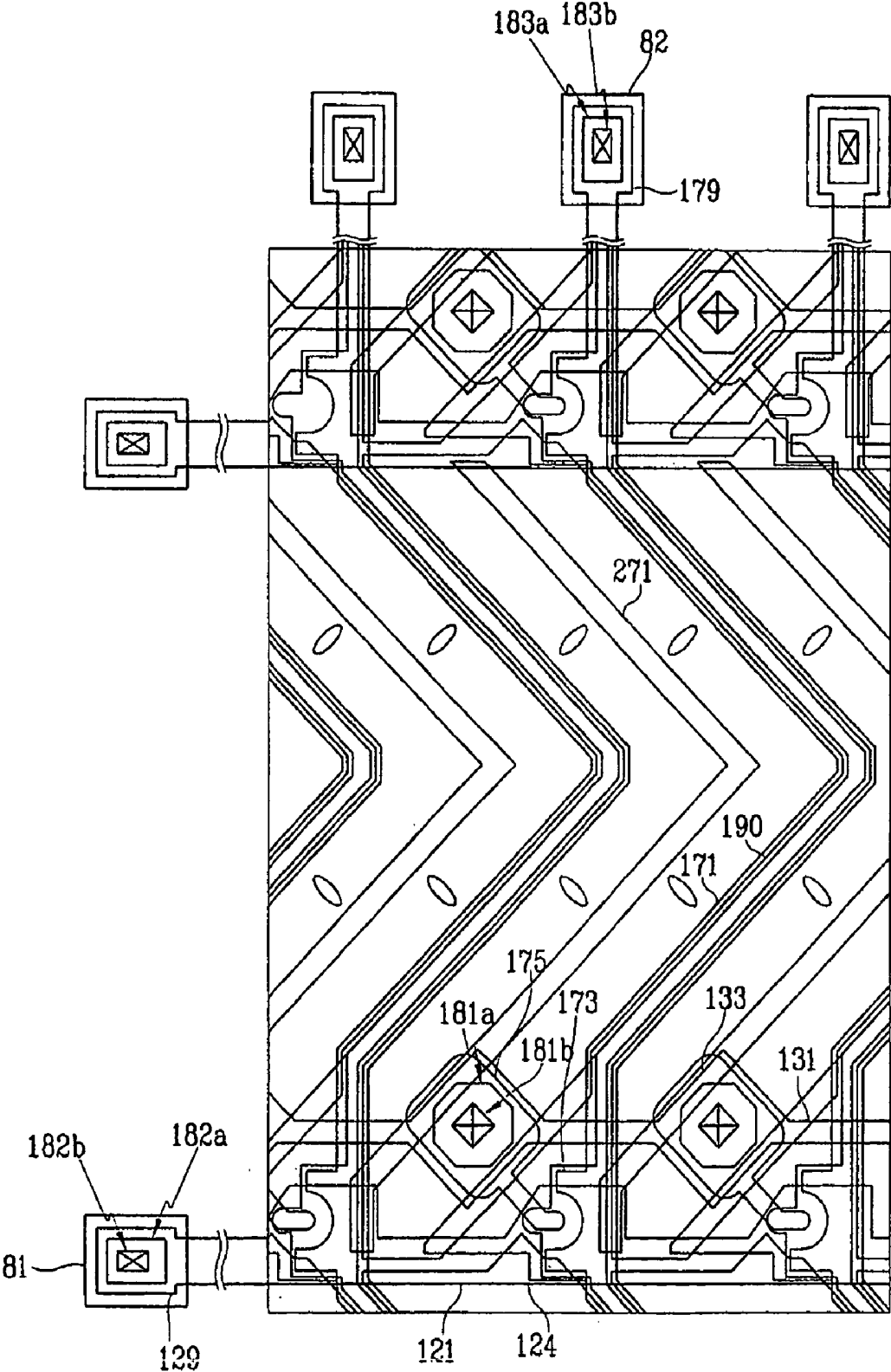


FIG.31

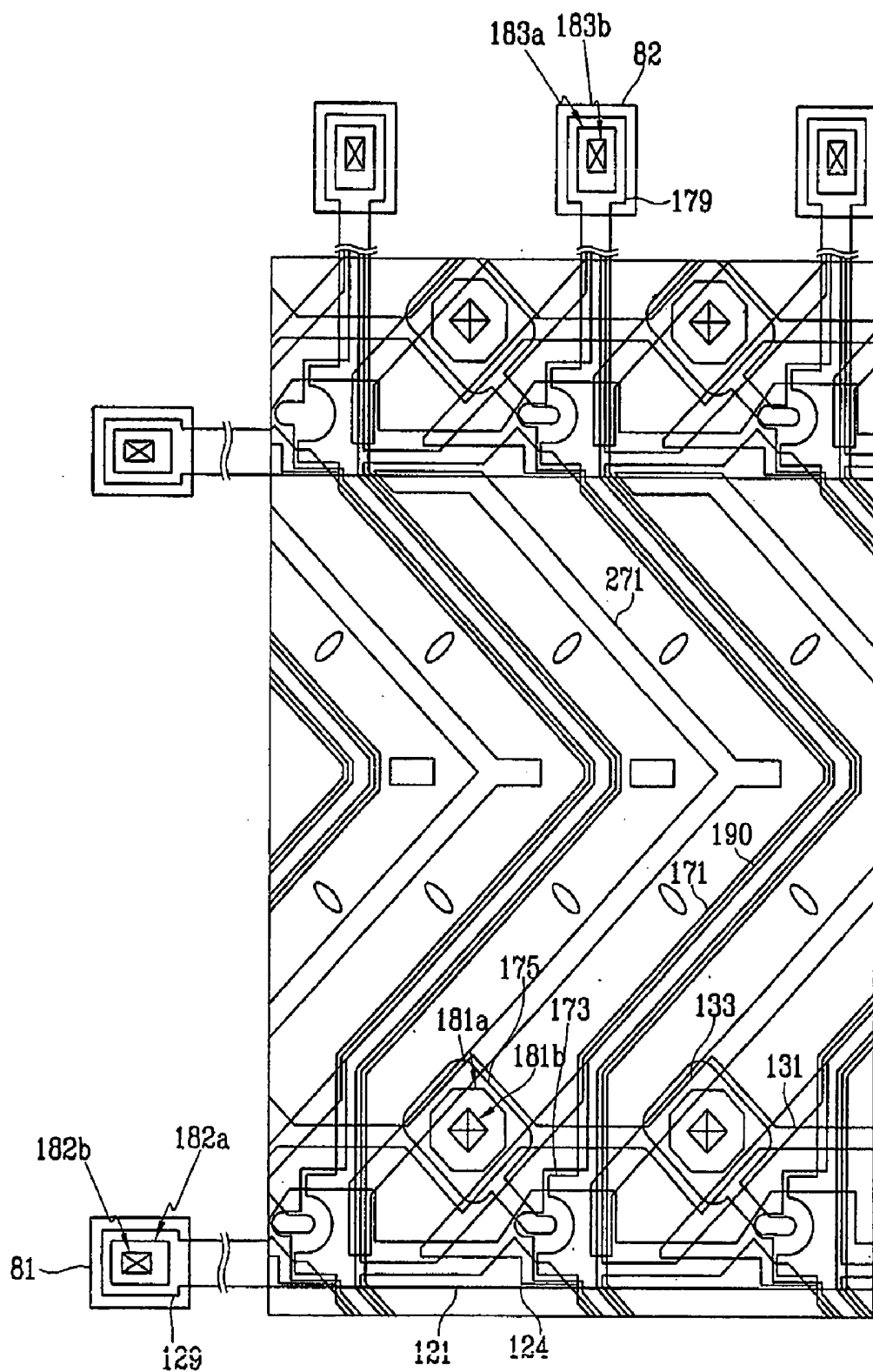




FIG.32

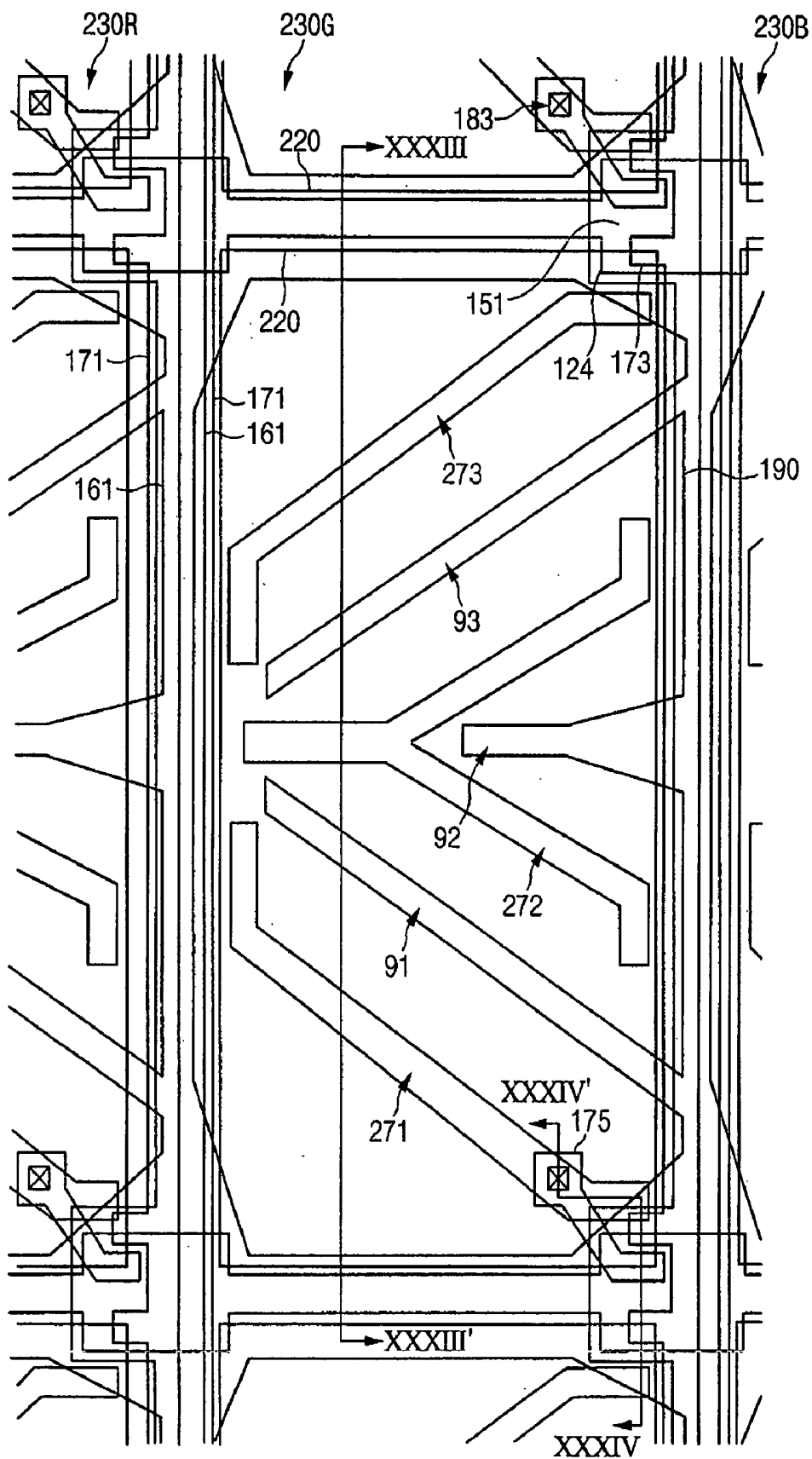


FIG.33

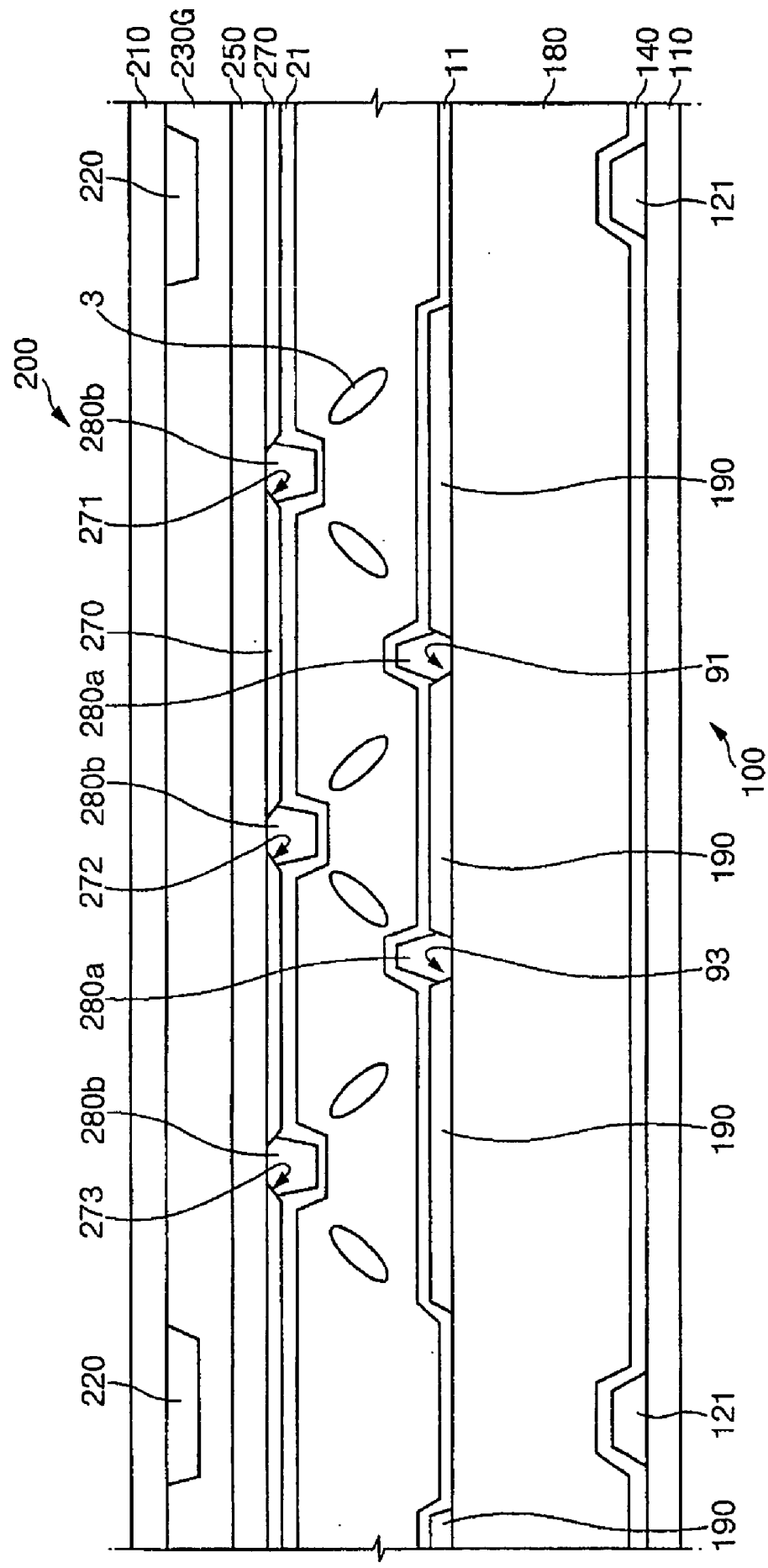




FIG.35

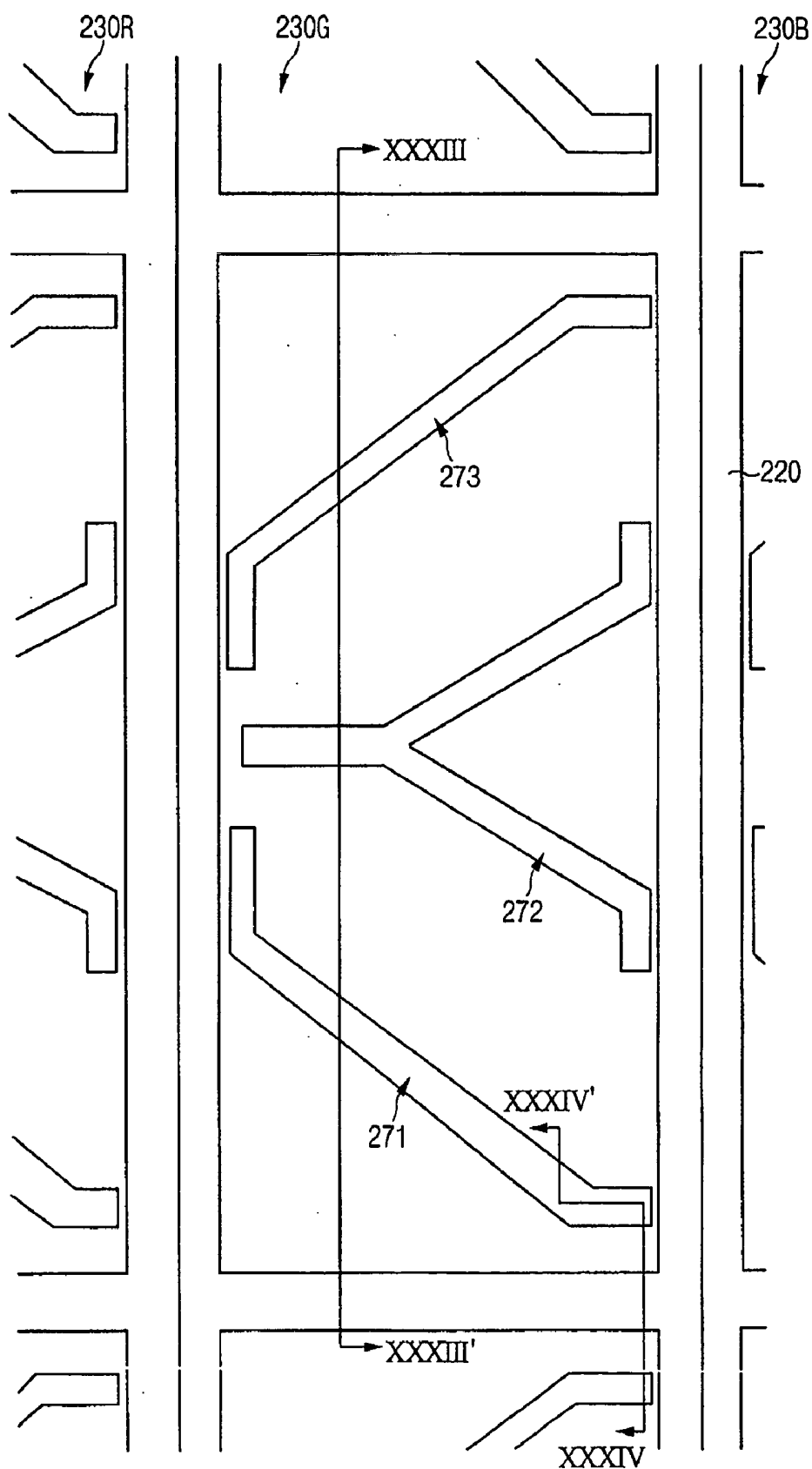


FIG.36

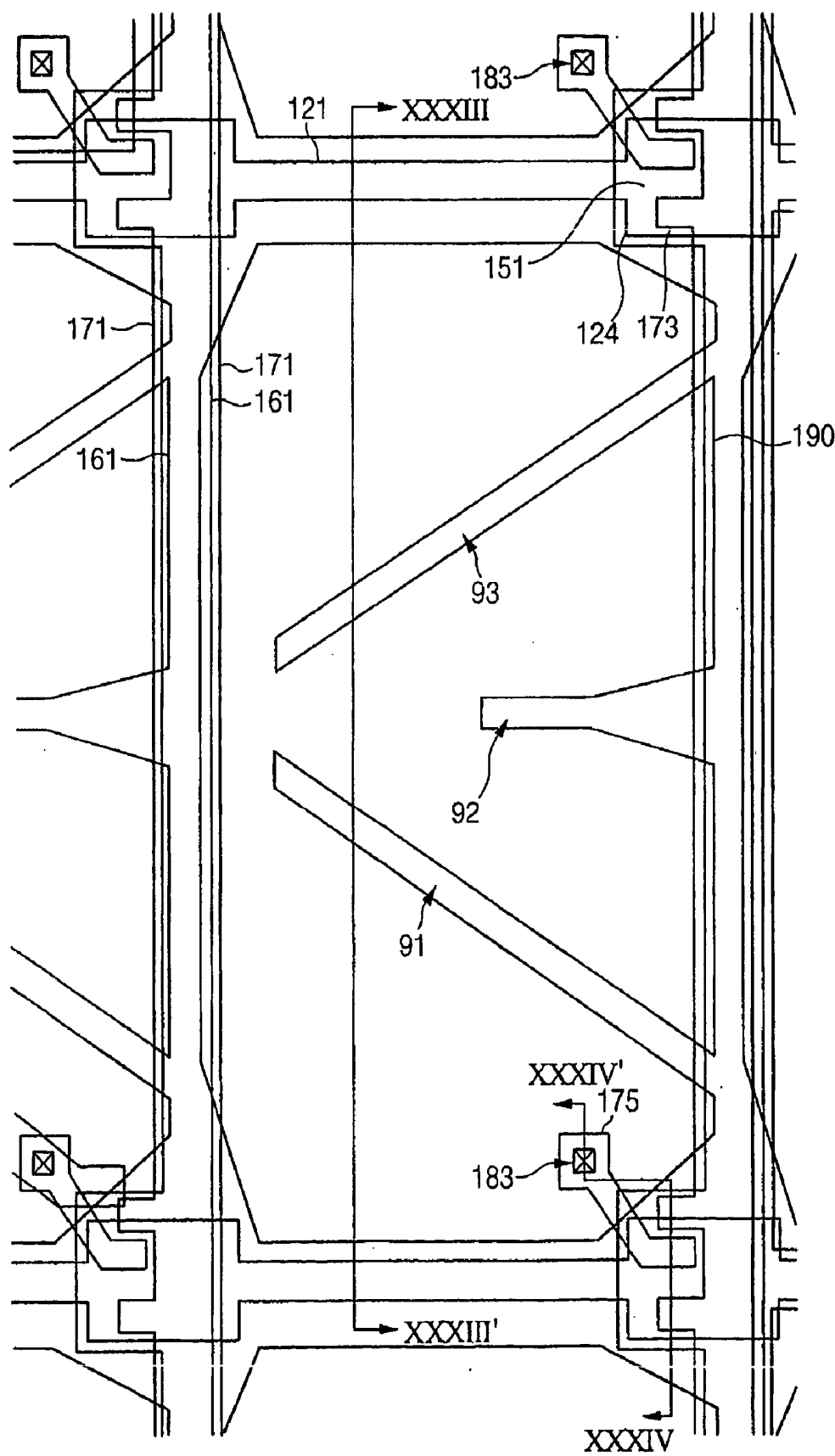


FIG.37

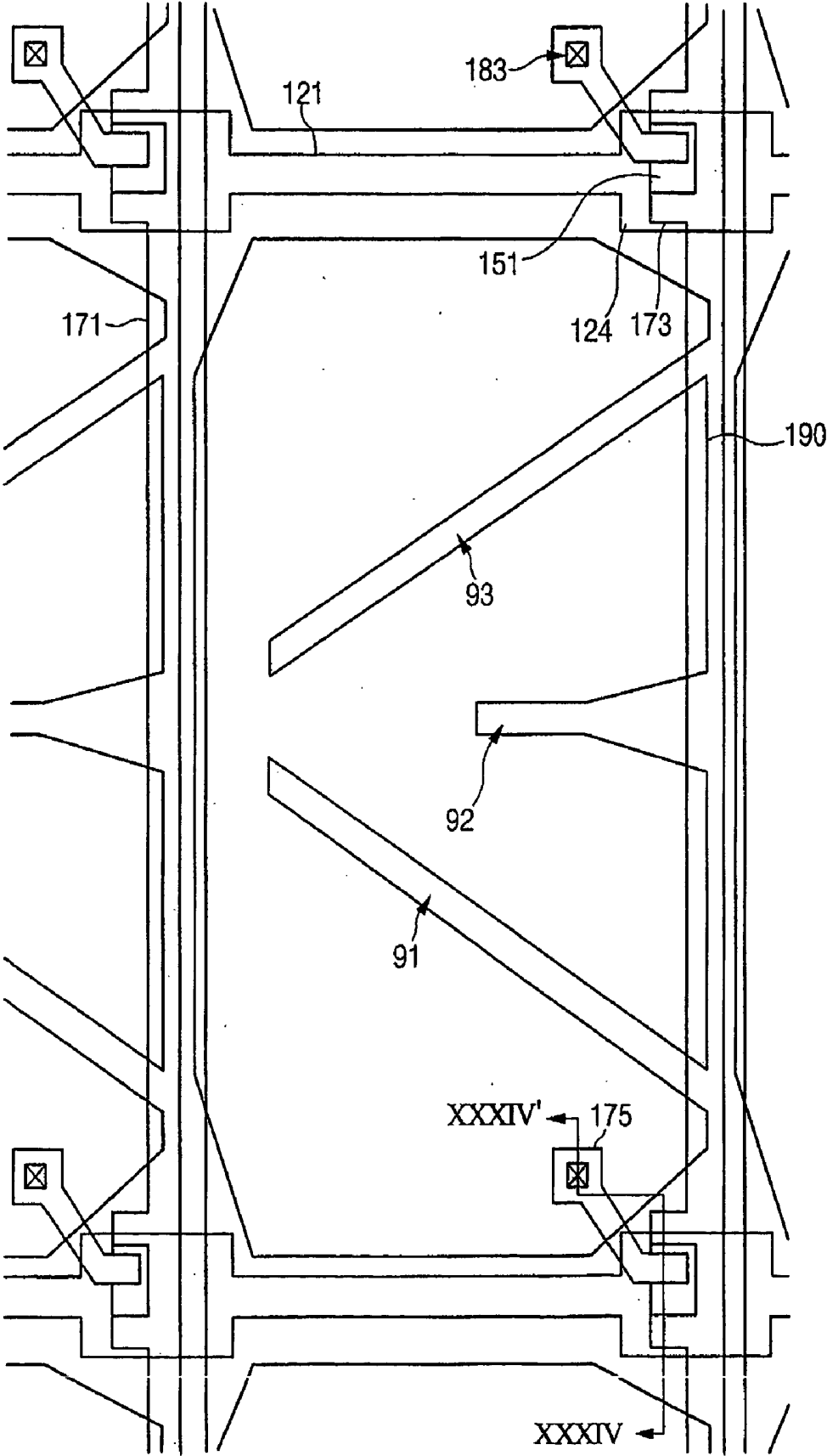
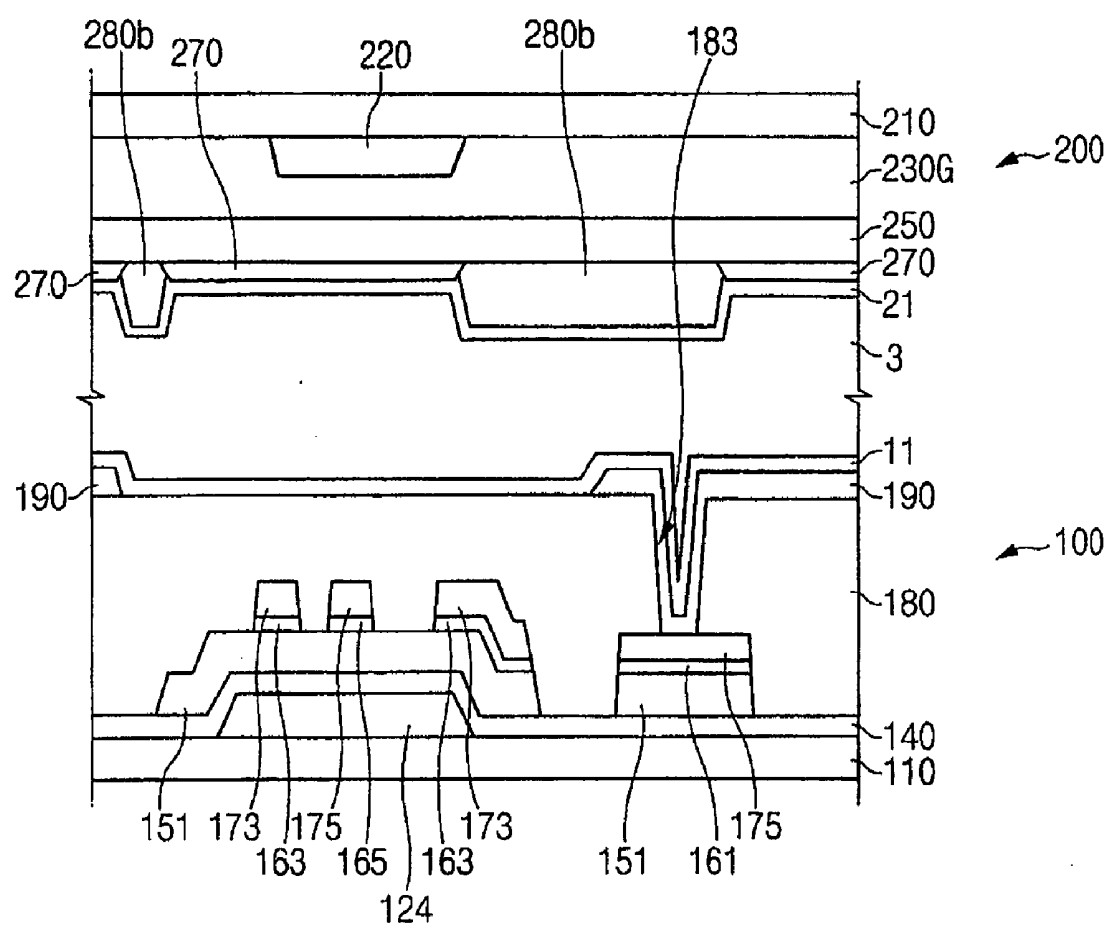


FIG.38







## LIQUID CRYSTAL DISPLAY AND THIN FILM TRANSISTOR ARRAY PANEL THEREFOR

### BACKGROUND OF THE INVENTION

#### [0001] 1. Field of the Invention

[0002] The present invention relates to a liquid crystal display and a thin film transistor array panel therefor.

#### [0003] 2. Description of the Related Art

[0004] A liquid crystal display (LCD) is one of the most widely used flat panel displays. LCDs are used in notebook or laptop computers, desktop computer monitors and televisions. LCDs are lightweight and occupy less space than conventional cathode ray tube (CRT) displays.

[0005] The general structure of an LCD consists of a liquid crystal (LC) layer that is positioned between pair of panels including field generating electrodes and polarizers. The LC layer is subject to an electric field generated by the electrodes and variations in the field strength change the molecular orientation of the LC layer. For example, upon application of an electric field, the molecules of the LC layer change their orientation and polarize light passing through the LC layer. Appropriately positioned polarized filters block the polarized light, creating dark areas that can represent desired images.

[0006] One measure of LCD quality is viewing angle (i.e., the available area when viewing the LCD in which minimum contrast can be seen). Various techniques for enlarging the viewing angle have been suggested, including a technique utilizing a vertically aligned LC layer and providing cutouts or protrusions at field generating electrodes. However, cutouts and the protrusions reduce the aperture ratio to decrease the luminance of the LCD. To increase aperture ratio, it has been suggested that the size of the pixel electrodes be maximized. However, maximization of the size of the pixel electrodes results in a close distance between the pixel electrodes, causing strong lateral electric fields between the pixel electrodes. The strong electric fields cause unwanted altering of the orientation of the LC molecules, yielding textures and light leakage and deteriorating display characteristics.

### SUMMARY OF THE INVENTION

[0007] A thin film transistor array panel is provided, which includes: a substrate; a gate line formed on the substrate and including a gate electrode; a gate insulating layer formed on the gate line; a semiconductor layer formed on the gate insulating layer; a data line formed at least in part on the semiconductor layer; a drain electrode formed on the semiconductor layer at least in part and separated from the data line; a first passivation layer formed on the data line and the drain electrode; a first protrusion formed on the first passivation layer and disposed opposite the data line; and a pixel electrode formed on the first passivation layer and connected to the drain electrode.

[0008] The pixel electrode may have a cutout and the thin film transistor array panel may further include a second protrusion disposed in the cutout.

[0009] The thin film transistor array panel may further include a storage electrode line overlapping the pixel electrode, and the storage electrode line may include an expansion

sion overlapping the drain electrode. The storage electrode line may include a branch overlapping the cutout.

[0010] The first protrusion may be wider than the data line, and the data line may be curved.

[0011] The thin film transistor array panel may further include a spacer having a height larger than the first protrusion and disposed on the same layer as the first protrusion. The first protrusion and the spacer may include organic material.

[0012] The thin film transistor array panel may further include a color filter disposed between the first passivation layer and the first protrusion and the pixel electrode, and it may also include a second passivation layer formed on the color filter and the first protrusion and the pixel electrode.

[0013] The semiconductor layer may have substantially the same planar shape as the data line and the drain electrode.

[0014] A thin film transistor array panel is provided, which includes: a substrate; a gate line formed on the substrate and including a gate electrode; a gate insulating layer formed on the gate line; a semiconductor layer formed on the gate insulating layer; a data line formed at least in part on the semiconductor layer; a drain electrode formed on the semiconductor layer at least in part and separated from the data line; a first passivation layer formed on the data line and the drain electrode and having a contact hole exposing the drain electrode at least in part; a pixel electrode formed on the first passivation layer and connected to the drain electrode through the contact hole; and a protrusion formed on the first passivation layer and disposed in the cutout at least in part.

[0015] The thin film transistor array panel may further include a storage electrode line overlapping the pixel electrode, and the storage electrode line may include an expansion overlapping the drain electrode. The storage electrode line may include a branch overlapping the cutout.

[0016] The data line may be curved.

[0017] The thin film transistor array panel may further include a spacer having a height larger than the protrusion and disposed on the same layer as the protrusion. The first protrusion and the spacer may include organic material.

[0018] The thin film transistor array panel may further include a color filter disposed between the first passivation layer and the protrusion and the pixel electrode, and it may also include a second passivation layer formed on the color filter and the protrusion and the pixel electrode.

[0019] The thin film transistor array panel may further include a color filter disposed between the first passivation layer and the protrusion and the pixel electrode, and it may also include a second passivation layer formed on the color filter and the protrusion and the pixel electrode.

[0020] The semiconductor layer may have substantially the same planar shape as the data line and the drain electrode.

[0021] A liquid crystal display is provided, which includes: a first substrate; a gate line formed on the first substrate; a data line intersecting the gate line; a thin film transistor connected to the gate line and the data line; a pixel electrode connected to the thin film transistor and having a

first cutout; a second substrate facing the first substrate; a common electrode formed on the second substrate and having a second cutout; and a first protrusion disposed in at least one of the first and the second cutouts at least in part.

[0022] The liquid crystal display may further includes: a light blocking member disposed on one of the first and the second substrates; and a color filter disposed on one of the first and the second substrates.

[0023] The liquid crystal display may further include a second protrusion disposed on the data line.

[0024] The first cutout does not overlap the second cutout.

#### BRIEF DESCRIPTION OF THE DRAWINGS

[0025] The present invention will become more apparent by describing preferred embodiments thereof in detail with reference to the accompanying drawings in which:

[0026] **FIG. 1** is a layout view of a TFT array panel for an LCD according to an embodiment of the present invention;

[0027] **FIG. 2** is a layout view of a common electrode panel for an LCD according to an embodiment of the present invention;

[0028] **FIG. 3** is a layout view of an LCD including the TFT array panel shown in **FIG. 1** and the common electrode panel shown in **FIG. 2**;

[0029] **FIG. 4** is a sectional view of the LCD shown in **FIG. 3** taken along the line IV-IV';

[0030] **FIG. 5** is a sectional view of the LCD shown in **FIG. 3** taken along the lines V-V' and V'-V'';

[0031] **FIGS. 6A and 6B** are sectional views of the TFT array panel shown in **FIGS. 1, 4 and 5** taken along the line IV-IV' and the lines V-V' and V'-V'', respectively, in an intermediate step of a manufacturing method thereof according to an embodiment of the present invention;

[0032] **FIGS. 7A and 7B** are sectional views of the TFT array panel shown in **FIGS. 1, 4 and 5** taken along the line IV-IV' and the lines V-V' and V'-V'', respectively, in the step of the manufacturing method following the step shown in **FIGS. 6A and 6B**;

[0033] **FIGS. 8A and 8B** are sectional views of the TFT array panel shown in **FIGS. 1, 4 and 5** taken along the line IV-IV' and the lines V-V' and V'-V'', respectively, in the step of the manufacturing method following the step shown in **FIGS. 7A and 7B**;

[0034] **FIG. 9** is a layout view of an LCD according to another embodiment of the present invention;

[0035] **FIG. 10** is a sectional view of the LCD shown in **FIG. 9** taken along the line X-X';

[0036] **FIG. 11** is a sectional view of the LCD shown in **FIG. 9** taken along the lines XI-XI' and XI'-XI'';

[0037] **FIGS. 12A and 12B** are sectional views of the TFT array panel shown in **FIGS. 9-11** taken along the line X-X' and the lines XI-XI', respectively, in an intermediate step of a manufacturing method thereof according to an embodiment of the present invention;

[0038] **FIGS. 13A and 13B** are sectional views of the TFT array panel shown in **FIGS. 9-11** taken along the line X-X'

and the lines XI-XI' and XI'-XI'' in the step of the manufacturing method following the step shown in **FIGS. 12A and 12B**;

[0039] **FIGS. 14A and 14B** are sectional views of the TFT array panel shown in **FIGS. 9-11** taken along the line X-X' and the lines XI-XI' and XI'-XI'' in the step of the manufacturing method following the step shown in **FIGS. 13A and 13B**;

[0040] **FIGS. 15A and 15B** are sectional views of the TFT array panel shown in **FIGS. 9-11** taken along the line X-X' and the lines XI-XI' and XI'-XI'' in the step of the manufacturing method following the step shown in **FIGS. 14A and 14B**;

[0041] **FIG. 16** is a layout view of an LCD according to another embodiment of the present invention;

[0042] **FIG. 17** is a sectional view of the LCD shown in **FIG. 16** taken along the line XVII-XVII';

[0043] **FIG. 18** is a sectional view of the LCD shown in **FIG. 16** taken along the lines XVIII-XVIII' and XVIII'-XVIII'';

[0044] **FIG. 19** is a layout view of an LCD according to another embodiment of the present invention;

[0045] **FIG. 20** is a sectional view of the LCD shown in **FIG. 19** taken along the line XX-XX';

[0046] **FIG. 21** is a sectional view of the LCD shown in **FIG. 19** taken along the lines XXI-XXI' and XXI'-XXI'';

[0047] **FIGS. 22 and 23** are sectional views of an LCD according to another embodiment of the present invention;

[0048] **FIGS. 24 and 25** are sectional views of an LCD according to another embodiment of the present invention;

[0049] **FIGS. 26 and 27** are sectional views of an LCD according to another embodiment of the present invention;

[0050] **FIGS. 28 and 29** are sectional views of an LCD according to another embodiment of the present invention;

[0051] **FIG. 30** is a layout view of an LCD according to another embodiment of the present invention;

[0052] **FIG. 31** is a layout view of an LCD according to another embodiment of the present invention;

[0053] **FIG. 32** is a layout view of a TFT array panel of an LCD according to another embodiment of the present invention;

[0054] **FIG. 33** is a sectional view of the LCD shown in **FIG. 32** taken along the line XXXIII-XXXIII';

[0055] **FIG. 34** is a sectional view of the LCD shown in **FIG. 32** taken along the line XXXIV-XXXIV';

[0056] **FIG. 35** is a layout view of a common electrode panel shown in **FIGS. 32-34**;

[0057] **FIG. 36** is a layout view of a TFT array panel shown in **FIGS. 32-34**;

[0058] **FIG. 37** is a layout view of an LCD according to another embodiment of the present invention;

[0059] **FIG. 38** is a sectional view of the LCD shown in **FIG. 37** taken along the line XXXVII-XXXVII'; and

[0060] FIG. 39 is a sectional view of the LCD shown in FIG. 32 taken along the line XXXIII-XXXIII' according to an embodiment of the present invention.

#### DETAILED DESCRIPTION OF PREFERRED EMBODIMENTS

[0061] The present invention now will be described more fully hereinafter with reference to the accompanying drawings, in which preferred embodiments of the invention are shown. The present invention may, however, be embodied in many different forms and should not be construed as limited to the embodiments set forth herein.

[0062] In the drawings, the thickness of layers, films and regions are exaggerated for clarity. Like numerals refer to like elements throughout. It will be understood that when an element such as a layer, film, region or substrate is referred to as being "on" another element, it can be directly on the other element or intervening elements may also be present. In contrast, when an element is referred to as being "directly on" another element, there are no intervening elements present.

[0063] Now, liquid crystal displays and thin film transistor (TFT) array panels for LCDs according to embodiments of the present invention will be described with reference to the accompanying drawings.

[0064] FIG. 1 is a layout view of a TFT array panel for an LCD according to an embodiment of the present invention, FIG. 2 is a layout view of a common electrode panel for an LCD according to an embodiment of the present invention, FIG. 3 is a layout view of an LCD including the TFT array panel shown in FIG. 1 and the common electrode panel shown in FIG. 2, FIG. 4 is a sectional view of the LCD shown in FIG. 3 taken along the line IV-IV', and FIG. 5 is a sectional view of the LCD shown in FIG. 3 taken along the lines V-V' and V'-V''.

[0065] An LCD according to an embodiment of the present invention includes a TFT array panel 100, a common electrode panel 200 facing the TFT array panel 100, and a LC layer 3 interposed between the TFT array panel 100 and the common electrode panel 200.

[0066] The TFT array panel 100 is now described in detail with reference to FIGS. 1, 4 and 5.

[0067] A plurality of gate lines 121 and a plurality of storage electrode lines 131 are formed on an insulating substrate 110.

[0068] The gate lines 121 extend substantially in a transverse direction and are separated from each other and transmit gate signals. Each gate line 121 includes a plurality of projections forming a plurality of gate electrodes 124 and an end portion 129 having a large area for contact with another layer or an external device.

[0069] Each storage electrode line 131 extends substantially in the transverse direction and includes a plurality of projections forming storage electrodes 133. Each storage electrode 133 has a shape of a diamond or a rectangle rotated by about 45 degrees and they are located close to the gate lines 121. The storage electrode lines 131 are supplied with a predetermined voltage such as a common voltage, which is applied to a common electrode 270 on the common electrode panel 200 of the LCD.

[0070] The gate lines 121 and the storage electrode lines 131 have a multi-layered structure including two films having different physical characteristics, a lower film and an upper film. The upper film is preferably made of low resistivity metal including Al containing metal such as Al and Al alloy, Ag containing metal such as Ag and Ag alloy, or Cu containing metal such as Cu and Cu alloy for reducing signal delay or voltage drop in the gate lines 121 and the storage electrode lines 131. On the other hand, the lower film is preferably made of material such as Cr, Mo, Mo alloy, Ta, or Ti, which has good physical, chemical, and electrical contact characteristics with other materials such as indium tin oxide (ITO) or indium zinc oxide (IZO). A good exemplary combination of the lower film material and the upper film material is Cr and Al—Nd alloy. In FIGS. 4, the lower and the upper films of the gate electrodes 124 are indicated by reference numerals 241 and 242, respectively, the lower and the upper films of the end portions 129 are indicated by reference numerals 291 and 292, respectively, and the lower and the upper films of the storage electrodes 133 are indicated by reference numerals 331 and 332, respectively. Portions of the upper film 292 of the end portions 129 of the gate lines 121 are removed to expose the underlying portions of the lower films 291.

[0071] The gate lines 121 and the storage electrode lines 131 may have a single layer structure or may include three or more layers.

[0072] In addition, the lateral sides of the gate lines 121 and the storage electrode lines 131 are inclined relative to a surface of the substrate 110, and the inclination angle thereof ranges about 30-80 degrees.

[0073] A gate insulating layer 140 preferably made of silicon nitride (SiNx) is formed on the gate lines 121 and the storage electrode lines 131.

[0074] A plurality of semiconductor stripes 151 preferably made of hydrogenated amorphous silicon (abbreviated as "a-Si") or polysilicon are formed on the gate insulating layer 140. Each semiconductor stripe 151 extends substantially in the longitudinal direction while it is curved periodically. Each semiconductor stripe 151 has a plurality of projections 154 branched out toward the gate electrodes 124. Each semiconductor island 150 is located opposite the gate electrodes 124.

[0075] A plurality of ohmic contact stripes and islands 161 and 165 preferably made of silicide or n+ hydrogenated a-Si heavily doped with n type impurity are formed on the semiconductor stripes 151. Each ohmic contact stripe 161 has a plurality of projections 163, and the projections 163 and the ohmic contact islands 165 are located in pairs on the projections 154 of the semiconductor stripes 151.

[0076] The lateral sides of the semiconductor stripes 151 and the ohmic contacts 161 and 165 are inclined relative to a surface of the substrate 110, and the inclination angles thereof are preferably in a range between about 30-80 degrees.

[0077] A plurality of data lines 171 and a plurality of drain electrodes 175 separated from each other are formed on the ohmic contacts 161 and 165 and the gate insulating layer 140.

[0078] The data lines 171 for transmitting data voltages extend substantially in the longitudinal direction and inter-

sect the gate lines **121** and the storage electrode lines **131**. Each data line **171** has an end portion **179** having a large area for contact with another layer or an external device and it includes a plurality of pairs of oblique portions and a plurality of longitudinal portions such that it curves periodically. A pair of oblique portions are connected to each other to form a chevron and opposite ends of the pair of oblique portions are connected to respective longitudinal portions. The oblique portions of the data lines **171** make an angle of about 45 degrees with the gate lines **121**, and the longitudinal portions cross over the gate electrodes **124**.

[0079] Each drain electrode **175** includes a rectangular expansion overlapping a storage electrode **133**. The edges of the expansion of the drain electrode **175** are substantially parallel to the edges of the storage electrodes **133**. Each longitudinal portion of the data lines **171** includes a plurality of projections such that the longitudinal portion including the projections forms a source electrode **173** partly enclosing an end portion of a drain electrode **175**. Each set of a gate electrode **124**, a source electrode **173**, and a drain electrode **175** along with a projection **154** of a semiconductor stripe **151** form a TFT having a channel formed in the semiconductor projection **154** disposed between the source electrode **173** and the drain electrode **175**.

[0080] The data lines **171** and the drain electrodes **175** also include a lower film **711** and **751** preferably made of Mo, Mo alloy or Cr and an upper film **712** and **752** located thereon and preferably made of Al containing metal. In FIGS. 4 and 5, the lower and the upper films of the source electrodes **173** are indicated by reference numerals **731** and **732**, respectively, and the lower and the upper films of the end portions **179** of the data lines **171** are indicated by reference numerals **791** and **792**, respectively. Portion of the upper films **792**, **752** of the expansions **179** of the data lines **171** and the drain electrodes **175** are removed to expose the underlying portions of the lower films **791** and **751**.

[0081] Like the gate lines **121** and the storage electrode lines **131**, the data lines **171** and the drain electrodes **175** have inclined lateral sides, and the inclination angles thereof about 30-80 degrees.

[0082] The ohmic contacts **161** and **165** are interposed only between the underlying semiconductor stripes **151** and the overlying data lines **171** and the overlying drain electrodes **175** thereon and reduce the contact resistance therebetween.

[0083] A passivation layer **180** is formed on the data lines **171** and the drain electrodes **175**, and exposed portions of the semiconductor stripes **151**, which are not covered with the data lines **171** and the drain electrodes **175**. The passivation layer **180** is preferably made of photosensitive organic material having a good flatness characteristic, low dielectric insulating material such as a-Si:C:O and a-Si:O:F formed by plasma enhanced chemical vapor deposition (PECVD), or inorganic material such as silicon nitride and silicon oxide. The passivation layer **180** may have a double-layered structure including a lower inorganic film and an upper organic film.

[0084] The passivation layer **180** has a plurality of contact holes **181b** and **183b** exposing the drain electrodes **175** and the end portions **179** of the data lines **171**, respectively. The passivation layer **180** and the gate insulating layer **140** have

a plurality of contact holes **182b** exposing the end portions **129** of the gate lines **121**. The contact holes **181b**, **182b** and **183b** can have various shapes such as polygon or circle. The area of each contact hole **182b** or **183b** is preferably equal to or larger than  $0.5\text{ mm}\times 15\text{ }\mu\text{m}$  and not larger than  $2\text{ mm}\times 60\text{ }\mu\text{m}$ . The sidewalls **181a**, **182a** and **183a** of the contact holes **181b**, **182b** and **183b** are inclined with an angle of about 30-85 degrees or have stepwise profiles.

[0085] A plurality of protrusions **280** are formed on the passivation layer **180** opposite the data lines **171**. The protrusions **280** may be wider than the data lines and decrease parasitic capacitances generated by the data lines **171** to reduce lateral field and texture.

[0086] A plurality of pixel electrodes **190** and a plurality of contact assistants **81** and **82**, which are preferably made of ITO or IZO, are formed on the passivation layer **180**.

[0087] Each pixel electrode **190** is located substantially in an area enclosed by the data lines **171** and the gate lines **121**, and thus it also forms a chevron. The pixel electrodes **190** cover the storage electrode lines **131** including the storage electrodes **133** and the expansions of the drain electrodes **175** and have chamfered edges substantially parallel to edges of the storage electrodes **133** that are close to the chamfered edges.

[0088] The pixel electrodes **190** are physically and electrically connected to the drain electrodes **175** through the contact holes **181** such that the pixel electrodes **190** receive the data voltages from the drain electrodes **175**. The pixel electrodes **190** supplied with the data voltages generate electric fields in cooperation with the common electrode **270**, which reorient liquid crystal molecules disposed therebetween.

[0089] A pixel electrode **190** and a common electrode form a capacitor called a "liquid crystal capacitor," which stores applied voltages after turn-off of the TFT. An additional capacitor called a "storage capacitor," which is connected in parallel to the liquid crystal capacitor, is provided for enhancing the voltage storing capacity. The storage capacitors are implemented by overlapping the pixel electrodes **190** with the storage electrode lines **131**. The capacitances of the storage capacitors, i.e., the storage capacitances are increased by providing the projections (i.e., the storage electrodes) **133** at the storage electrode lines **131**, elongating the drain electrodes **175** connected to the pixel electrodes **190**, and providing the expansions at the drain electrodes **175** overlapping the storage electrodes **133** of the storage electrode lines **131** for decreasing the distance between the terminals and increasing the overlapping areas.

[0090] The pixel electrodes **190** overlap the data lines **171** as well as the gate lines **121** to increase aperture ratio.

[0091] The protrusions **280** are disposed between the pixel electrodes **190**, and the pixel electrodes **190** may have cutouts (not shown) and additional protrusions may be disposed on the cutouts. In this case, the storage electrode lines **131** are preferably disposed under the cutouts.

[0092] The contact assistants **81** and **82** are connected to the exposed end portions **129** of the gate lines **121** and the exposed end portions **179** of the data lines **171** through the contact holes **181** and **182**, respectively. The contact assistants **81** and **82** and the contact holes **182b** and **183b** are

provided for signal communication between the signal lines **121** and **171** and external driving circuits mounted on the TFT array panel **100** or flexible printed circuit films that are attached to the TFT array panel **100**. When the driving circuits are formed on the substrate **110** along with the signal lines **121** and **171** and the TFTs, the contact assistants **81** and **82** and the contact holes **182b** and **183b** need not be provided.

[0093] Finally, an alignment layer **11** is formed on the pixel electrodes **190**, the contact assistants **81** and **82**, and the passivation layer **180**.

[0094] The description of the common electrode panel **200** follows with reference to FIGS. 2, 4 and 5.

[0095] A light blocking member called a light blocking member **220** is formed on an insulating substrate **210** such as transparent glass and it includes a plurality of oblique portions facing the oblique portions of the data lines **171** and a plurality of right-angled-triangular portions facing the TFTs and the longitudinal portions of the data lines **171** such that the light blocking member **220** prevents light leakage between the pixel electrodes **190** and defines open areas facing the pixel electrodes **190**. Each of the triangular portions of the light blocking member **220** has a hypotenuse parallel to a chamfered edge of a pixel electrode **190**.

[0096] A plurality of color filters **230** are formed on the substrate **210** and the light blocking member **220** and it is disposed substantially in the open areas defined by the light blocking member **220**. The color filters **230** disposed in adjacent two data lines **171** and arranged in the longitudinal direction may be connected to each other to form a stripe. Each color filter **230** may represent one of three primary colors such as red, green and blue colors.

[0097] An overcoat **250** preferably made of organic material is formed on the color filters **230** and the light blocking member **220**. The overcoat **250** protects the color filters **230** and prevents the color filters **230** from contaminating other layers and it has a flat top surface.

[0098] A common electrode **270** preferably made of transparent conductive material such as ITO and IZO is formed on the overcoat **250**. The common electrode **270** is supplied with the common voltage and it has a plurality of chevron-like cutouts **271**. Each cutout **271** includes a pair of oblique portions connected to each other, a transverse portion connected to one of the oblique portions, and a longitudinal portion connected to the other of the oblique portions. The oblique portions of the cutout **271** extend substantially parallel to the oblique portions of the data lines **171** and face a pixel electrode **190** so that they may bisect the pixel electrode **190** into left and right halves. The transverse and the longitudinal portions of the cutout **271** are aligned with transverse and longitudinal edges of the pixel electrode **190**, respectively, and they make obtuse angles with the oblique portions of the cutout **190**.

[0099] A homogeneous or homeotropic alignment layer **21** is coated on the common electrode **270**.

[0100] A pair of polarizers **12** and **22** are provided on outer surfaces of the panels **100** and **200** such that their transmissive axes are crossed and one of the transmissive axes is parallel to the gate lines **121**.

[0101] The LCD may further include at least one retardation film for compensating the retardation of the LC layer **3** and a backlight unit for providing light for the LCD.

[0102] The LC layer **3** has negative dielectric anisotropy and the LC molecules in the LC layer **3** are aligned such that their long axes are vertical to the surfaces of the panels **100** and **200** in absence of electric field.

[0103] Upon application of the common voltage to the common electrode **270** and a data voltage to the pixel electrodes **190**, a primary electric field substantially perpendicular to the surfaces of the panels **100** and **200** is generated. The LC molecules tend to change their orientations in response to the electric field such that their long axes are perpendicular to the field direction. In the meantime, the cutouts **271** of the common electrode **270** and the edges of the pixel electrodes **190** distort the primary electric field to have a horizontal component which determines the tilt directions of the LC molecules. The horizontal component of the primary electric field is perpendicular to the edges of the cutouts **271** and the edges of the pixel electrodes **190**.

[0104] In the meantime, the protrusions **280** give pretilt angles to the LC molecules to facilitate the tilt of the LC molecules. In addition, the protrusions **280** may strengthen the horizontal component of the primary field. Accordingly, the width of the cutouts **91-93** can be decreased to improve the aperture ratio, thereby increasing the luminance of the LCD.

[0105] Accordingly, four sub-regions having different tilt directions, which are partitioned by edges of a pixel electrode **190**, a cutout **271** bisecting the pixel electrode **190**, and an imaginary transverse center line passing through the meeting point of the oblique portions of the cutout **271**, are formed in a pixel region of the LC layer **3**, which are located on the pixel electrode **190**. Each sub-region has two major edges defined by the cutout **271** and an oblique edge of the pixel electrode **190**, respectively.

[0106] In the meantime, the direction of a secondary electric field due to the voltage difference between the pixel electrodes **190** is perpendicular to the edges of the cutouts **271**. Accordingly, the field direction of the secondary electric field coincides that of the horizontal component of the primary electric field. Consequently, the secondary electric field between the pixel electrodes **190** enhances the determination of the tilt directions of the LC molecules.

[0107] Since the LCD performs inversion such as dot inversion, column inversion, etc., adjacent pixel electrodes are supplied with data voltages having opposite polarity with respect to the common voltage and thus a secondary electric field between the adjacent pixel electrodes is almost always generated to enhance the stability of the domains.

[0108] Since the tilt directions of all domains make an angle of about 45 degrees with the gate lines **121**, which are parallel to or perpendicular to the edges of the panels **100** and **200**, and the 45-degree intersection of the tilt directions and the transmissive axes of the polarizers minimizes light leakage, the polarizers can be attached such that the transmissive axes of the polarizers are parallel to or perpendicular to the edges of the panels **100** and **200** and it reduces the production cost.

[0109] The resistance increase of the data lines **171** due to the curving can be compensated by widening the data lines

171 since distortion of the electric field and increase of the parasitic capacitance due to the increase of the width of the data lines 171 can be compensated by maximizing the size of the pixel electrodes 190 and by adapting a thick organic passivation layer.

[0110] A method of manufacturing the TFT array panel shown in FIGS. 1-5 according to an embodiment of the present invention will be now described in detail with reference to FIGS. 6A, 6B, 7A and 7B, and 8A and 8B as well as FIGS. 1-5.

[0111] FIGS. 6A and 6B are sectional views of the TFT array panel shown in FIGS. 1, 4 and 5 taken along the line IV-IV' and the lines V-V' and V'-V'', respectively, in an intermediate step of a manufacturing method thereof according to an embodiment of the present invention, FIGS. 7A and 7B are sectional views of the TFT array panel shown in FIGS. 1, 4 and 5 taken along the line IV-IV' and the lines V-V' and V'-V'', respectively, in the step of the manufacturing method following the step shown in FIGS. 6A and 6B, and FIGS. 8A and 8B are sectional views of the TFT array panel shown in FIGS. 1, 4 and 5 taken along the line IV-IV' and the lines V-V' and V'-V'', respectively, in the step of the manufacturing method following the step shown in FIGS. 7A and 7B.

[0112] Referring to FIGS. 1, 6A and 6B, a lower conductive film preferably made of Cr, Mo, or Mo alloy and an upper conductive film preferably made of Al containing metal or Ag containing metal are sputtered in sequence on an insulating substrate 110 and they are wet or dry etched in sequence to form a plurality of gate lines 121, each including a plurality of gate electrodes 124 and an expansion 129, and a plurality of storage electrode lines 131 including a plurality of storage electrodes 133. In FIGS. 6A and 6B, the lower and the upper films of the gate electrodes 124 are indicated by reference numerals 241 and 242, respectively, the lower and the upper films of the expansions 129 are indicated by reference numerals 291 and 292, respectively, and the lower and the upper films of the storage electrodes 133 are indicated by reference numerals 331 and 332, respectively.

[0113] After sequential deposition of a gate insulating layer 140 with thickness of about 1,500-5,000 Å, an intrinsic a-Si layer with thickness of about 500-2,000 Å, and an extrinsic a-Si layer with thickness of about 300-600 Å, the extrinsic a-Si layer and the intrinsic a-Si layer are photo-etched to form a plurality of extrinsic semiconductor stripes and a plurality of intrinsic semiconductor stripes 151 including a plurality of projections 154 on the gate insulating layer 140.

[0114] Subsequently, two conductive films including a lower conductive film and an upper conductive film and having a thickness of 1,500-3,000 Å are sputtered in sequence and patterned to form a plurality of data lines 171, each including a plurality of source electrodes 173 and an expansion 179, and a plurality of drain electrodes 175. The lower conductive film is preferably made of Cr, Mo, or Mo alloy, and the upper conductive film is preferably made of Al containing metal or Ag containing metal. In FIGS. 6A and 6B, the lower and the upper films of the drain electrodes 171 are indicated by reference numerals 711 and 712, respectively, the lower and the upper films of the source electrodes 173 are indicated by reference numerals 731 and 732, respectively, the lower and the upper films of the drain

electrodes 175 are indicated by reference numerals 751 and 752, respectively, and the lower and the upper films of the end portions 179 of the data lines 171 are indicated by reference numerals 791 and 792, respectively.

[0115] Thereafter, portions of the extrinsic semiconductor stripes, which are not covered with the data lines 171 and the drain electrodes 175, are removed to complete a plurality of ohmic contact stripes 161 including a plurality of projections 163 and a plurality of ohmic contact islands 165 and to expose portions of the intrinsic semiconductor stripes 151. Oxygen plasma treatment preferably follows in order to stabilize the exposed surfaces of the semiconductor stripes 151.

[0116] Referring to FIGS. 1, 7A and 7B, a passivation layer 180 made of a photosensitive organic insulator is coated and exposed through a photo-mask 500 having a plurality of transmissive areas 502 and a plurality of slit areas 501 disposed around the transmissive areas 502. Accordingly, portions of the passivation layer 180 facing the transmissive areas 502 absorb the full energy of the light, while portions of the passivation layer 180 facing the slit areas 501 partially absorb the light energy. The passivation layer 180 is then developed to form a plurality of contact holes 181b and 183b exposing portions of the drain electrodes 175 and portions of the expansions 179 of the data lines 171, respectively, and to form upper portions of a plurality of contact holes 182b exposing portions of the gate insulating layer 140 disposed on the expansions 129 of the gate lines 121. Since the portions of the passivation layer 180 facing the transmissive areas 502 are removed to its full thickness, while the portions facing the slit areas 501 remain to have reduced thickness, sidewalls 181a, 182a and 183a of the contact holes 181b, 182b and 183b have stepped profiles.

[0117] Referring to FIGS. 1, 8A and 8B, an organic layer is coated and patterned by photolithography to form a plurality of protrusions 280.

[0118] After removing the exposed portions of the gate insulating layer 140 to expose the underlying portions of the expansions 129 of the gate insulating layer 140, the exposed portions of the upper conductive films 752, 792 and 292 of the drain electrodes 175, the expansions 179 of the data lines 171, and the expansions 129 of the gate lines 121 are removed to expose underlying portions of the lower conductive films 751, 791 and 291 of the drain electrodes 175, the expansions 179 of the data lines 171, and the expansions 129 of the gate lines 121.

[0119] Next, a plurality of pixel electrodes 190 and a plurality of contact assistants 92 and 82 are formed on the passivation layer 180 and on the exposed portions of the lower conductive films 751, 791 and 291 of the drain electrodes 175, the expansions 129 of the gate lines 121, and the expansions 179 of the data lines 171 by sputtering and photo-etching an IZO or ITO layer with thickness of about 400-500 Å as shown in FIGS. 1, 4 and 5.

[0120] Finally, an alignment layer 11 is formed on the pixel electrodes 190, the protrusions 280, and the passivation layer 180.

[0121] An LCD according to another embodiment of the present invention will be described in detail with reference to FIGS. 9-11.

[0122] FIG. 8 is a layout view of an LCD according to another embodiment of the present invention, FIG. 10 is a sectional view of the LCD shown in FIG. 9 taken along the line X-X', and FIG. 11 is a sectional view of the LCD shown in FIG. 9 taken along the lines XI-XI' and XI'-XI".

[0123] Referring to FIGS. 9-11, an LCD according to this embodiment also includes a TFT array panel 100, a common electrode panel 200, and a LC layer 3 interposed therebetween.

[0124] Layered structures of the panels 100 and 200 according to this embodiment are almost the same as those shown in FIGS. 1-5.

[0125] Regarding the TFT array panel 100, a plurality of gate lines 121 including a plurality of gate electrodes 124 and a plurality of storage electrode lines 131 including a plurality of storage electrodes 133 are formed on a substrate 110, and a gate insulating layer 140, a plurality of semiconductor stripes 151 including a plurality of projections 154, and a plurality of ohmic contact stripes 161 including a plurality of projections 163 and a plurality of ohmic contact islands 165 are sequentially formed thereon. A plurality of data lines 171 including a plurality of source electrodes 173 and a plurality of drain electrodes 175 are formed on the ohmic contacts 161 and 165, and a passivation layer 180 is formed thereon. A plurality of contact holes 181b, 182b and 183b are provided at the passivation layer 180 and the gate insulating layer 140, and a plurality of protrusions 280 are formed on the passivation layer 180. A plurality of pixel electrodes 190 and a plurality of contact assistants 81 and 82 are formed on the passivation layer 180 and an alignment layer 11 is formed thereon.

[0126] Regarding the common electrode panel 200, a light blocking member 220, a plurality of color filters 230, an overcoat 250, a common electrode 270, and an alignment layer 21 are formed on an insulating substrate 210.

[0127] Different from the LCD shown in FIGS. 1-5, the semiconductor stripes 151 have almost the same planar shapes as the data lines 171 and the drain electrodes 175 as well as the underlying ohmic contacts 161 and 165. However, the projections 154 of the semiconductor stripes 151 include some exposed portions, which are not covered with the data lines 171 and the drain electrodes 175, such as portions located between the source electrodes 173 and the drain electrodes 175.

[0128] Many of the above-described features of the LCD shown in FIGS. 1-5 may be appropriate to the LCD shown in FIGS. 9-11.

[0129] Now, a method of manufacturing the TFT array panel shown in FIGS. 9-11 according to an embodiment of the present invention will be described in detail.

[0130] FIGS. 12A and 12B are sectional views of the TFT array panel shown in FIGS. 9-11 taken along the line X-X' and the lines XI-XI' and XI'-XI", respectively, in an intermediate step of a manufacturing method thereof according to an embodiment of the present invention; FIGS. 13A and 13B are sectional views of the TFT array panel shown in FIGS. 9-11 taken along the line X-X' and the lines XI-XI' and XI'-XI" in the step of the manufacturing method following the step shown in FIGS. 12A and 12B; FIGS. 14A and 14B are sectional views of the TFT array panel shown

in FIGS. 9-11 taken along the line X-X' and the lines XI-XI' and XI'-XI" in the step of the manufacturing method following the step shown in FIGS. 13A and 13B; and FIGS. 15A and 15B are sectional views of the TFT array panel shown in FIGS. 9-11 taken along the line X-X' and the lines XI-XI' and XI'-XI" in the step of the manufacturing method following the step shown in FIGS. 14A and 14B.

[0131] Referring to FIGS. 12A and 12B, two conductive films, a lower conductive film and an upper conductive film are sputtered in sequence on an insulating substrate 110 and they are wet or dry etched in sequence to form a plurality of gate lines 121, each including a plurality of gate electrodes 124 and an expansion 129, and a plurality of storage electrode lines 131 including a plurality of storage electrodes 133. In FIGS. 12A and 12B, the lower and the upper films of the gate electrodes 124 are indicated by reference numerals 241 and 242, respectively, the lower and the upper films of the expansions 129 are indicated by reference numerals 291 and 292, respectively, and the lower and the upper films of the storage electrodes 133 are indicated by reference numerals 331 and 332, respectively.

[0132] Next, a gate insulating layer 140, an intrinsic a-Si layer 150, and an extrinsic a-Si layer 160 are sequentially deposited by CVD such that the layers 140, 150 and 160 bear thickness of about 1,500-5,000 Å, about 500-2,000 Å and about 300-600 Å, respectively. A conductive layer 170 including a lower film 701 and an upper film 702 is deposited by sputtering, and a photoresist film with the thickness of about 1-2 microns is coated on the conductive layer 170.

[0133] The photoresist film is exposed to light through an exposure mask 600 including slit areas 601, and developed such that the developed photoresist PR has a position dependent thickness. The photoresist shown in FIGS. 12A and 12B includes a plurality of first to third portions with decreased thickness. The first portions are located on first areas (referred to as "wire areas" hereinafter) and the second portions are located on second areas (referred to as "channel areas" hereinafter), respectively, while the third portions located on remaining third areas are not illustrated in the figures since they have substantially zero thickness to expose underlying portions of the conductive layer 170.

[0134] The different thickness of the photoresist PR enables to selectively etch the underlying layers when using suitable process conditions. Therefore, a plurality of data lines 171 including a plurality of source electrodes 173, and a plurality of drain electrodes 175 as well as a plurality of ohmic contact stripes 161 including a plurality of projections 163, a plurality of ohmic contact islands 165 and a plurality of semiconductor stripes 151 including a plurality of projections 154 are obtained by a series of etching steps as shown in FIGS. 13A and 13B. In FIGS. 13A and 13B, the lower and the upper films of the drain electrodes 171 are indicated by reference numerals 711 and 712, respectively, the lower and the upper films of the source electrodes 173 are indicated by reference numerals 731 and 732, respectively, the lower and the upper films of the drain electrodes 175 are indicated by reference numerals 751 and 752, respectively, and the lower and the upper films of the end portions 179 of the data lines 171 are indicated by reference numerals 791 and 792, respectively.

[0135] For descriptive purpose, portions of the conductive layer 170, the extrinsic a-Si layer 160, and the intrinsic a-Si

layer **150** on the wire areas are called first portions, portions of the conductive layer **170**, the extrinsic a-Si layer **160**, and the intrinsic a-Si layer **150** on the channel areas are called second portions, and portions of the conductive layer **170**, the extrinsic a-Si layer **160**, and the intrinsic a-Si layer **150** on the third areas are called third portions.

[0136] An exemplary sequence of forming such a structure is as follows:

[0137] (1) Removal of third portions of the conductive layer **170**, the extrinsic a-Si layer **160** and the intrinsic a-Si layer **150** on the wire areas;

[0138] (2) Removal of the second portions of the photoresist;

[0139] (3) Removal of the second portions of the conductive layer **170** and the extrinsic a-Si layer **160** on the channel areas; and

[0140] (4) Removal of the first portions of the photoresist.

[0141] Another exemplary sequence is as follows:

[0142] (1) Removal of the third portions of the conductive layer **170**;

[0143] (2) Removal of the second portions of the photoresist;

[0144] (3) Removal of the third portions of the extrinsic a-Si layer **160** and the intrinsic a-Si layer **150**;

[0145] (4) Removal of the second portions of the conductive layer **170**;

[0146] (5) Removal of the first portions of the photoresist; and

[0147] (6) Removal of the second portions of the extrinsic a-Si layer **160**.

[0148] The first example is described in detail.

[0149] At first, the exposed third portions of the conductive layer **170** on the third areas are removed by wet etching or dry etching to expose the underlying third portions of the extrinsic a-Si layer **160**. The dry etching may etch out the top portions of the photoresist PR.

[0150] Next, the third portions of the extrinsic a-Si layer **160** on the third areas and of the intrinsic a-Si layer **150** are removed preferably by dry etching and the second portions of the photoresist PR are removed to expose the second portions of the conductors **170**. The removal of the second portions of the photoresist PR are performed either simultaneously with or independent from the removal of the third portions of the extrinsic a-Si layer **160** and of the intrinsic a-Si layer **150**. A gas mixture of SF<sub>6</sub> and HCl or a gas mixture of SF<sub>6</sub> and O<sub>2</sub> can etch the a-Si layers **150** and **160** and the photoresist PR by nearly the same etching ratio. Residue of the second portions of the photoresist PR remained on the channel areas is removed by ashing.

[0151] Next, the third portions of the extrinsic a-Si layer **160** on the third areas and of the intrinsic a-Si layer **150** are removed preferably by dry etching and the second portions of the photoresist PR are removed to expose the second portions of the conductors **170**. The removal of the second portions of the photoresist PR are performed either simul-

taneously with or independent from the removal of the third portions of the extrinsic a-Si layer **160** and of the intrinsic a-Si layer **150**. A gas mixture of SF<sub>6</sub> and HCl or a gas mixture of SF<sub>6</sub> and O<sub>2</sub> can etch the a-Si layers **150** and **160** and the photoresist PR by nearly the same etching ratio. Residue of the second portions of the photoresist PR remained on the channel areas is removed by ashing.

[0152] The semiconductor stripes **151** are completed in this step.

[0153] Next, the second portions of the conductors **170** and the extrinsic a-Si layer **160** on the channel areas as well as the first portion of the photoresist PR are removed.

[0154] Both the conductors **170** and the extrinsic a-Si layer **160** may be dry etched.

[0155] Alternatively, the conductors **170** are wet etched, while the extrinsic a-Si layer **160** is dry etched. Since the wet etch etches out lateral sides of the conductors **170**, while the dry etch hardly etch out lateral sides of the extrinsic a-Si layer **160**, step-wise lateral profiles are obtained. Examples of the gas mixtures are CF<sub>4</sub> and HCl and CF<sub>4</sub> and O<sub>2</sub>, as described above. The latter gas mixture leaves uniform thickness of the intrinsic semiconductor stripes **151**.

[0156] In this way, each conductor **170** is divided into a data line **171** and a plurality of drain electrodes **175** to be completed, and the extrinsic a-Si layer **160** is divided into an ohmic contact stripe **161** and a plurality of ohmic contact islands **165** to be completed.

[0157] Referring to FIGS. 14A and 14B, a passivation layer **180** made of a photosensitive organic insulator is coated and exposed through a photo-mask **900** having a plurality of transmissive areas **902** and a plurality of slit areas **901** disposed around the transmissive areas **902**. Accordingly, portions of the passivation layer **180** facing the transmissive areas **902** absorb the full energy of the light, while portions of the passivation layer **180** facing the slit areas **901** partially absorb the light energy. The passivation layer **180** is then developed to form a plurality of contact holes **181b** and **183b** exposing portions of the drain electrodes **175** and portions of the expansions **179** of the data lines **171**, respectively, and to form upper portions of a plurality of contact holes **182b** exposing portions of the gate insulating layer **140** disposed on the expansions **129** of the gate lines **121**. Since the portions of the passivation layer **180** facing the transmissive areas **902** are removed to its full thickness, while the portions facing the slit areas **901** remain to have reduced thickness, sidewalls **181a**, **182a** and **183a** of the contact holes **181b**, **182b** and **183b** have stepped profiles.

[0158] Referring to FIGS. 1, 8A and 8B, an organic layer is coated and patterned by photolithography to form a plurality of protrusions **280**.

[0159] After removing the exposed portions of the gate insulating layer **140** to expose the underlying portions of the expansions **129** of the gate insulating layer **140**, the exposed portions of the upper conductive films **752**, **792** and **292** of the drain electrodes **175**, the expansions **179** of the data lines **171**, and the expansions **129** of the gate lines **121** are removed to expose underlying portions of the lower conductive films **751**, **791** and **291** of the drain electrodes **175**, the expansions **179** of the data lines **171**, and the expansions **129** of the gate lines **121**.



[0160] The passivation layer **180** may be made of a photo-insensitive organic insulator or inorganic insulator having a low dielectric constant less than 4. In this case, an additional etching step for forming the contact holes **181b**, **182b** and **183b** is required.

[0161] A plurality of pixel electrodes **190** and a plurality of contact assistants **92** and **82** are formed on the passivation layer **180** and on the exposed portions of the lower conductive films **751**, **791** and **291** of the drain electrodes **175**, the expansions **129** of the gate lines **121**, and the expansions **179** of the data lines **171** by sputtering and photo-etching an IZO or ITO film with thickness of about 400-500 Å as shown in FIGS. 9-11.

[0162] The etching of the IZO film may include wet etching using a Cr etchant such as  $\text{HNO}_3/(\text{NH}_4)_2\text{Ce}(\text{NO}_3)_6/\text{H}_2\text{O}$ , which does not erode the exposed Al portions of the drain electrodes **175**, the gate lines **121**, and the data lines **171** through the contact holes **181b**, **182b** and **183b**. A preferred deposition temperature for minimizing the contact resistance ranges from room temperature to about 200° C. A sputtering target for depositing IZO preferably includes  $\text{In}_2\text{O}_3$  and ZnO and the content of ZnO is preferably in a range about 15-20 atomic %.

[0163] Nitrogen, which can prevent the formation of metal oxides on the exposed portions of the drain electrodes **175**, the gate lines **121**, and the data lines **171** through the contact holes **181b**, **182b** and **183b**, is preferably used for a pre-heating process before the deposition of the ITO film or the IZO film.

[0164] Finally, an alignment layer **280** is formed thereon.

[0165] An LCD according to another embodiment of the present invention will be described in detail with reference to FIGS. 16-18.

[0166] FIG. 16 is a layout view of an LCD according to another embodiment of the present invention, FIG. 17 is a sectional view of the LCD shown in FIG. 16 taken along the line XVII-XVII', and FIG. 18 is a sectional view of the LCD shown in FIG. 16 taken along the lines XVIII-XVIII' and XVIII'-XVIII''.

[0167] Referring to FIGS. 16-18, an LCD according to this embodiment also includes a TFT array panel **100**, a common electrode panel **200**, and a LC layer **3** interposed therebetween.

[0168] Regarding a TFT array panel **100**, a plurality of gate lines **121** including a plurality of gate electrodes **124** and a plurality of storage electrode lines **131** including a plurality of storage electrodes **133** are formed on a substrate **110**, and a gate insulating layer **140**, a plurality of semiconductor stripes **151** including a plurality of projections **154**, and a plurality of ohmic contact stripes **161** including a plurality of projections **163** and a plurality of ohmic contact islands **165** are sequentially formed thereon. A plurality of data lines **171** including a plurality of source electrodes **173** and a plurality of drain electrodes **175** are formed on the ohmic contacts **161** and **165** and the gate insulating layer **140**.

[0169] A first passivation layer **801** preferably made of inorganic insulator such as  $\text{SiNx}$  is formed on the data lines **171** and the drain electrodes **175**.

[0170] A plurality of red, green and blue color filters **230R**, **230G** and **230B** is formed on the first passivation layer **801** and they are disposed substantially between the data lines **171**. The color filters **230R**, **230G** or **230B** in adjacent two data lines **171** and arranged in the longitudinal direction may be connected to each other to form a periodically-curved stripe. The neighboring color filters **230R**, **230G** and **230B** overlap each other on the data lines **171** to form hills. The color filters **230R**, **230G** and **230B** have a plurality of openings disposed on the drain electrodes **175** and are not provided on a peripheral area which is provided with the expansions **129** and **179** of the gate lines **121** and the data lines **179**.

[0171] A second passivation layer **802** preferably made of photosensitive organic material is formed on the color filters **230R**, **230G** and **230B**. The second passivation layer **802** also forms hills when running over the hills formed by the color filters **230R**, **230G** and **230B** and the hills of the second passivation layer **802** enhance the control of the tilt directions of LC molecules in the LC layer **3**. The second passivation layer **802** prevents the color filters **230R**, **230G** and **230B** from contaminating the pixel electrodes **190** and it may be made of inorganic insulator such as  $\text{SiNx}$  and  $\text{SiO}_2$ .

[0172] The passivation layers **801** and **802** have a plurality of contact holes **181b** and **183b**, and the passivation layers **801** and **802** and the gate insulating layer **140** have a plurality of contact holes **182b**. The openings of the color filters **230R**, **230G** and **230B** expose the contact holes **181b** and a top surface of the first passivation layer **801**.

[0173] A plurality of protrusions **280** are formed on the second passivation layer **802**.

[0174] A plurality of pixel electrodes **190** and a plurality of contact assistants **81** and **82** are formed on the second passivation layer **802** and an alignment layer **11** is formed thereon.

[0175] The common electrode panel **200** includes a light blocking member **220**, a common electrode **270**, and an alignment layer **21** formed on an insulating substrate **210**. Comparing the common electrode panel **200** shown in FIGS. 2, 4 and 5, the common electrode panel **200** shown in FIGS. 16-18 has no color filter and no overcoat.

[0176] Since the color filters **230R**, **230G** and **230B** and the pixel electrodes **190** are provided on the TFT array panel **100**, the LCD shown in FIGS. 16-18 may have a large alignment margin for aligning the TFT array panel **100** and the common electrode panel **200**.

[0177] A TFT array panel **100** shown in FIGS. 16-18 may be manufactured by depositing a first passivation layer **801**, forming a plurality of red, green, and blue color filters **230R**, **230G**, and **230B**, coating a second passivation layer **802** made of a photosensitive organic layer, exposing and developing the passivation layer **802** to form upper portions of a plurality of contact holes **181b**, **182b** and **183b**, forming a plurality of protrusions **280**, removing exposed portions of the first passivation layer **801** and the gate insulating layer **140** to form lower portions of the contact holes **181b**, **182b** and **183b**, forming a plurality of pixel electrodes **190** and a plurality of contact assistants **81** and **82**, and coating an alignment layer **11**, after forming the gate lines **121**, the storage electrode lines **131**, the gate insulating layer **140**, the

semiconductor stripes **151**, the ohmic contacts **161** and **165**, the data lines **171**, and the drain electrodes **175** as described above with reference to **FIGS. 6A-7B**. The formation of the color filters **230R**, **230G**, and **230B** includes thrice repetitions of coating, exposing, and developing a photosensitive film including a colored pigment.

[0178] Many of the above-described features of the LCD shown in **FIGS. 1-5** may be appropriate to the LCD shown in **FIGS. 16-18**.

[0179] An LCD according to another embodiment of the present invention will be described in detail with reference to **FIGS. 19-21**.

[0180] **FIG. 19** is a layout view of an LCD according to another embodiment of the present invention, **FIG. 20** is a sectional view of the LCD shown in **FIG. 19** taken along the line XX-XX', and **FIG. 21** is a sectional view of the LCD shown in **FIG. 19** taken along the lines XXI-XXI' and XXI'-XXI''.

[0181] Referring to **FIGS. 19-21**, an LCD according to this embodiment also includes a TFT array panel **100**, a common electrode panel **200**, and a LC layer **3** interposed therebetween.

[0182] Layered structures of the panels **100** and **200** according to this embodiment are almost the same as those shown in **FIGS. 16-18**.

[0183] Concerning the TFT array panel **100**, a plurality of gate lines **121** and a plurality of storage electrode lines **131** are formed on a substrate **110**, and a gate insulating layer **140**, a plurality of semiconductor stripes **151** including a plurality of projections **154**, and a plurality of ohmic contact stripes **161** including a plurality of projections **163** and a plurality of ohmic contact islands **165** are sequentially formed thereon. A plurality of data lines **171** and a plurality of drain electrodes **175** are formed on the ohmic contacts **161** and **165**, and a first passivation layer **801** is formed thereon. A plurality of red, green and blue color filters **230R**, **230G** and **230B** are formed on the first passivation layer **801** and a second passivation layer **802** is formed thereon. A plurality of contact holes **181b**, **182b** and **183b** are provided at the first and the second passivation layers **801** and **802** and the gate insulating layer **140**, and a plurality of protrusions **280** are formed on the second passivation layer **802**. A plurality of pixel electrodes **190** and a plurality of contact assistants **81** and **82** are formed on the second passivation layer **802** and an alignment layer **11** is formed thereon.

[0184] Concerning the common electrode panel **200**, a light blocking member **220**, a common electrode **270**, and an alignment layer **21** are sequentially formed on an insulating substrate **210**.

[0185] Different from the LCD shown in **FIGS. 16-18**, the semiconductor stripes **151** have almost the same planar shapes as the data lines **171** and the drain electrodes **175** as well as the underlying ohmic contacts **161** and **165**. However, the projections **154** of the semiconductor stripes **151** include some exposed portions, which are not covered with the data lines **171** and the drain electrodes **175** such as portions located between the source electrodes **173** and the drain electrodes **175**.

[0186] A TFT array panel **100** shown in **FIGS. 19-21** may be manufactured by forming a first passivation layer **801**, a

plurality of red, green, and blue color filters **230R**, **230G**, and **230B**, a second passivation layer **802**, a plurality of protrusions **280**, a plurality of pixel electrodes **190**, a plurality of contact assistants **81** and **82**, and an alignment layer **11** based on the steps described with reference to **FIGS. 16-18**, after forming the gate lines **121**, the storage electrode lines **131**, the gate insulating layer **140**, the semiconductor stripes **151**, the ohmic contacts **161** and **165**, the data lines **171**, and the drain electrodes **175** based on the steps described with reference to **FIGS. 12A-13B**.

[0187] Many of the above-described features of the LCD shown in **FIGS. 16-18** may cover the LCD shown in **FIGS. 19-21**.

[0188] An LCD according to another embodiment of the present invention will be described in detail with reference to **FIGS. 22 and 23**.

[0189] **FIGS. 22 and 23** are sectional views of an LCD according to another embodiment of the present invention, which have a similar layout as the LCD shown in **FIG. 16**.

[0190] Referring to **FIGS. 22 and 23**, an LCD according to this embodiment also includes a TFT array panel **100**, a common electrode panel **200**, and a LC layer **3** interposed therebetween.

[0191] Layered structures of the panels **100** and **200** according to this embodiment are almost the same as those shown in **FIGS. 17 and 18**.

[0192] Concerning the TFT array panel **100**, a plurality of gate lines **121** and a plurality of storage electrode lines **131** are formed on a substrate **110**, and a gate insulating layer **140**, a plurality of semiconductor stripes **151** including a plurality of projections **154**, and a plurality of ohmic contact stripes **161** including a plurality of projections **163** and a plurality of ohmic contact islands **165** are sequentially formed thereon. A plurality of data lines **171** and a plurality of drain electrodes **175** are formed on the ohmic contacts **161** and **165**, and a passivation layer **180** is formed thereon. A plurality of red, green and blue color filters **230R**, **230G**, and **230B** are formed on the passivation layer **180**, and a plurality of protrusions **280** are formed on the passivation layer **180**. A plurality of pixel electrodes **190** and a plurality of contact assistants **81** and **82** are formed on the passivation layer **180** and an alignment layer **11** is formed thereon. A plurality of contact holes **181b**, **182b** and **183b** are provided at the passivation layer **180** and the gate insulating layer **140**.

[0193] Concerning the common electrode panel **200**, a light blocking member **220**, a common electrode **270**, and an alignment layer **21** are sequentially formed on an insulating substrate **210**.

[0194] Different from the LCD shown in **FIGS. 16-18**, there is no additional passivation layer on the color filters **230R**, **230G**, and **230B**. Accordingly, lateral surfaces of openings of the color filters **230R**, **230G**, and **230B** exposing the contact holes **181b** serve as upper portions of sidewalls **181a** of the contact holes **181b** to smooth the profiles thereof as shown in **FIG. 22**. This structure is preferable when the color filters **230R**, **230G** and **230B** do not discharge impurities such as pigment.

[0195] Many of the above-described features of the LCD shown in **FIGS. 16-18** may cover the LCD shown in **FIGS. 22 and 23**.

[0196] An LCD according to another embodiment of the present invention will be described in detail with reference to FIGS. 24 and 25.

[0197] FIGS. 24 and 25 are sectional views of an LCD according to another embodiment of the present invention, which have a similar layout as the LCD shown in FIG. 19.

[0198] Referring to FIGS. 24 and 25, an LCD according to this embodiment also includes a TFT array panel 100, a common electrode panel 200, and a LC layer 3 interposed therebetween.

[0199] Layered structures of the panels 100 and 200 according to this embodiment are almost the same as those shown in FIGS. 22 and 23.

[0200] Concerning the TFT array panel 100, a plurality of gate lines 121 and a plurality of storage electrode lines 131 are formed on a substrate 110, and a gate insulating layer 140, a plurality of semiconductor stripes 151 including a plurality of projections 154, and a plurality of ohmic contact stripes 161 including a plurality of projections 163 and a plurality of ohmic contact islands 165 are sequentially formed thereon. A plurality of data lines 171 and a plurality of drain electrodes 175 are formed on the ohmic contacts 161 and 165, and a passivation layer 180 is formed thereon. A plurality of red, green and blue color filters 230R, 230G and 230B are formed on the passivation layer 180 and a plurality of protrusions 280 are formed on the color filters 230R, 230G and 230B. A plurality of contact holes 181b, 182b and 183b are provided at the passivation layer 180 and the gate insulating layer 140, and a plurality of pixel electrodes 190 and a plurality of contact assistants 81 and 82 are formed on the passivation layer 180. An alignment layer 11 is formed thereon.

[0201] Concerning the common electrode panel 200, a light blocking member 220, a common electrode 270, and an alignment layer 21 are sequentially formed on an insulating substrate 210.

[0202] Different from the LCD shown in FIGS. 22 and 23, the semiconductor stripes 151 have almost the same planar shapes as the data lines 171 and the drain electrodes 175 as well as the underlying ohmic contacts 161 and 165. However, the projections 154 of the semiconductor stripes 151 include some exposed portions, which are not covered with the data lines 171 and the drain electrodes 175 such as portions located between the source electrodes 173 and the drain electrodes 175.

[0203] Many of the above-described features of the LCD shown in FIGS. 22 and 23 may cover the LCD shown in FIGS. 24 and 25.

[0204] An LCD according to another embodiment of the present invention will be described in detail with reference to FIGS. 26 and 27.

[0205] FIGS. 26 and 27 are sectional views of an LCD according to another embodiment of the present invention, which have a similar layout as the LCD shown in FIG. 16.

[0206] Referring to FIGS. 26 and 27, an LCD according to this embodiment also includes a TFT array panel 100, a common electrode panel 200, and a LC layer 3 interposed therebetween.

[0207] Layered structures of the panels 100 and 200 according to this embodiment are almost the same as those shown in FIGS. 22 and 23.

[0208] Concerning the TFT array panel 100, a plurality of gate lines 121 and a plurality of storage electrode lines 131 are formed on a substrate 110, and a gate insulating layer 140, a plurality of semiconductor stripes 151 including a plurality of projections 154, and a plurality of ohmic contact stripes 161 including a plurality of projections 163 and a plurality of ohmic contact islands 165 are sequentially formed thereon. A plurality of data lines 171 and a plurality of drain electrodes 175 are formed on the ohmic contacts 161 and 165, and a passivation layer 180 is formed thereon. A plurality of red, green and blue color filters 230R, 230G, and 230B are formed on the passivation layer 180 and a plurality of protrusions 280 are formed on the passivation layer 180. A plurality of pixel electrodes 190 and a plurality of contact assistants 81 and 82 are formed on the passivation layer 180 and an alignment layer 11 is formed thereon. A plurality of contact holes 181b, 182b and 183b are provided at the passivation layer 180 and the gate insulating layer 140.

[0209] Concerning the common electrode panel 200, a light blocking member 220, a common electrode 270, and an alignment layer 21 are sequentially formed on an insulating substrate 210.

[0210] Different from the LCD shown in FIGS. 22 and 23, the color filters 230R, 230G or 230B are also disposed on a peripheral area which is provided with expansions 129 and 179 of the gate lines 121 and the data lines 179. Although FIG. 27 shows that a red color filter 230R is disposed on the peripheral area, any one or more of the red, green and blue color filters 230R, 230G and 230B may be provided on the peripheral area. In addition, the color filters 230R, 230G, and 230B have a plurality of openings forming upper portions of sidewalls 181a, 182a and 183a of the contact holes 181b, 182b and 183b. Accordingly, lateral surfaces of the openings of the color filters 230R, 230G, and 230B are smoothly connected to the lateral surfaces of the contact holes 181b, 182b and 183b at the passivation layer 180.

[0211] A TFT array panel 100 shown in FIGS. 24 and 25 may be manufactured by depositing a passivation layer 180, forming a plurality of red, green, and blue color filters 230R, 230G, and 230B having openings forming upper portions of a plurality of contact holes 181b, 182b and 183b exposing portions of the passivation layer 180, forming a plurality of protrusions 280, removing exposed portions of the passivation layer 180 and the gate insulating layer 140 to form lower portions of the contact holes 181b, 182b and 183b, forming a plurality of pixel electrodes 190 and a plurality of contact assistants 81 and 82, and coating an alignment layer 11, after forming the gate lines 121, the storage electrode lines 131, the gate insulating layer 140, the semiconductor stripes 151, the ohmic contacts 161 and 165, the data lines 171, and the drain electrodes 175 as described above with reference to FIGS. 6A-7B.

[0212] Many of the above-described features of the LCD shown in FIGS. 22 and 23 may cover the LCD shown in FIGS. 26 and 27.

[0213] An LCD according to another embodiment of the present invention will be described in detail with reference to FIGS. 28 and 29.

[0214] FIGS. 28 and 29 are sectional views of an LCD according to another embodiment of the present invention, which have a similar layout as the LCD shown in FIG. 19.

[0215] Referring to FIGS. 28 and 29, an LCD according to this embodiment also includes a TFT array panel 100, a common electrode panel 200, and a LC layer 3 interposed therebetween.

[0216] Layered structures of the panels 100 and 200 according to this embodiment are almost the same as those shown in FIGS. 26 and 27.

[0217] Concerning the TFT array panel 100, a plurality of gate lines 121 and a plurality of storage electrode lines 131 are formed on a substrate 110, and a gate insulating layer 140, a plurality of semiconductor stripes 151 including a plurality of projections 154, and a plurality of ohmic contact stripes 161 including a plurality of projections 163 and a plurality of ohmic contact islands 165 are sequentially formed thereon. A plurality of data lines 171 and a plurality of drain electrodes 175 are formed on the ohmic contacts 161 and 165, and a passivation layer 180 is formed thereon. A plurality of red, green and blue color filters 230R, 230G and 230B are formed on the passivation layer 180 and a plurality of protrusions 280 are formed on the passivation layer 180. A plurality of contact holes 181b, 182b and 183b are provided at the color filters 230R, 230G, and 230B, the passivation layer 180 and the gate insulating layer 140, and a plurality of pixel electrodes 190 and a plurality of contact assistants 81 and 82 are formed on the passivation layer 180. An alignment layer 11 is formed thereon.

[0218] Concerning the common electrode panel 200, a light blocking member 220, a common electrode 270, and an alignment layer 21 are sequentially formed on an insulating substrate 210.

[0219] Different from the LCD shown in FIGS. 26 and 27, the semiconductor stripes 151 have almost the same planar shapes as the data lines 171 and the drain electrodes 175 as well as the underlying ohmic contacts 161 and 165. However, the projections 154 of the semiconductor stripes 151 include some exposed portions, which are not covered with the data lines 171 and the drain electrodes 175 such as portions located between the source electrodes 173 and the drain electrodes 175.

[0220] Many of the above-described features of the LCD shown in FIGS. 26 and 27 may cover the LCD shown in FIGS. 28 and 29.

[0221] An LCD according to another embodiment of the present invention will be described in detail with reference to FIG. 30.

[0222] FIG. 30 is a layout view of an LCD according to another embodiment of the present invention.

[0223] The structure of the LCD according to this embodiment is almost the same as that shown in FIGS. 1-5. Referring to FIG. 30 as well as FIGS. 4 and 5, an LCD according to this embodiment also includes a TFT array panel 100, a common electrode panel 200, and a LC layer 3 interposed therebetween.

[0224] Regarding the TFT array panel 100, a plurality of gate lines 121 including a plurality of gate electrodes 124 and a plurality of storage electrode lines 131 including a

plurality of storage electrodes 133 are formed on a substrate 110, and a gate insulating layer 140, a plurality of semiconductor stripes 151 including a plurality of projections 154, and a plurality of ohmic contact stripes 161 including a plurality of projections 163 and a plurality of ohmic contact islands 165 are sequentially formed thereon. A plurality of data lines 171 including a plurality of source electrodes 173 and a plurality of drain electrodes 175 are formed on the ohmic contacts 161 and 165, and a passivation layer 180 is formed thereon. A plurality of contact holes 181b, 182b and 183b are provided at the passivation layer 180 and the gate insulating layer 140, and a plurality of protrusions 280 are formed on the passivation layer 180. A plurality of pixel electrodes 190 and a plurality of contact assistants 81 and 82 are formed on the passivation layer 180, and an alignment layer 11 is formed thereon.

[0225] Regarding the common electrode panel 200, a light blocking member 220, a plurality of color filters 230, an overcoat 250, a common electrode 270 having a plurality of cutouts 217, and an alignment layer 21 are formed on an insulating substrate 210. Each cutout 271 includes a pair of oblique portions connected to each other and a longitudinal portion connected to one of the oblique portions.

[0226] Different from the LCD shown in FIG. 3, the cutouts 271 of the common electrode 270 have no transverse portion.

[0227] Many of the above-described features of the LCD shown in FIGS. 1-5 may be appropriate to the LCD shown in FIG. 30.

[0228] An LCD according to another embodiment of the present invention will be described in detail with reference to FIG. 31.

[0229] FIG. 31 is a layout view of an LCD according to another embodiment of the present invention.

[0230] The structure of the LCD according to this embodiment is almost the same as that shown in FIGS. 1-5. Referring to FIG. 31 as well as FIGS. 4 and 5, an LCD according to this embodiment also includes a TFT array panel 100, a common electrode panel 200, and a LC layer 3 interposed therebetween.

[0231] Regarding the TFT array panel 100, a plurality of gate lines 121 including a plurality of gate electrodes 124 and a plurality of storage electrode lines 131 including a plurality of storage electrodes 133 are formed on a substrate 110, and a gate insulating layer 140, a plurality of semiconductor stripes 151 including a plurality of projections 154, and a plurality of ohmic contact stripes 161 including a plurality of projections 163 and a plurality of ohmic contact islands 165 are sequentially formed thereon. A plurality of data lines 171 including a plurality of source electrodes 173 and a plurality of drain electrodes 175 are formed on the ohmic contacts 161 and 165, and a passivation layer 180 is formed thereon. A plurality of contact holes 181b, 182b and 183b are provided at the passivation layer 180 and the gate insulating layer 140, and a plurality of protrusions 280 are formed on the passivation layer 180. A plurality of pixel electrodes 190 and a plurality of contact assistants 81 and 82 are formed on the passivation layer 180, and an alignment layer 11 is formed thereon.

[0232] Regarding the common electrode panel 200, a light blocking member 220, a plurality of color filters 230, an

overcoat **250**, a common electrode **270** having a plurality of cutouts **217**, and an alignment layer **21** are formed on an insulating substrate **210**. Each cutout **271** includes a pair of oblique portions connected to each other, a transverse edge portion connected to one of the oblique portions, and a longitudinal edge portion connected to the other of the oblique portions.

[0233] Different from the LCD shown in FIG. 3, each of the cutouts **271** of the common electrode **270** has a transverse center portion connected to a meeting point of the oblique portions and making an obtuse angle with the oblique portions. In addition, each of the pixel electrodes **190** has a transverse cutout coinciding with the transverse center portion of the common electrode **270**. The transverse portions of the pixel electrode **190** and the common electrode **270** assist the domain partitioning.

[0234] Many of the above-described features of the LCD shown in FIGS. 1-5 may be appropriate to the LCD shown in FIG. 31.

[0235] An LCD according to another embodiment of the present invention will be described in detail with reference to FIGS. 32-36.

[0236] FIG. 32 is a layout view of a TFT array panel of an LCD according to another embodiment of the present invention, FIG. 33 is a sectional view of the LCD shown in FIG. 32 taken along the line XXXIII-XXXIII', FIG. 34 is a sectional view of the LCD shown in FIG. 32 taken along the line XXXIV-XXXIV', FIG. 35 is a layout view of a common electrode panel shown in FIGS. 32-34, and FIG. 36 is a layout view of a TFT array panel shown in FIGS. 32-34.

[0237] An LCD according to an embodiment of the present invention includes a TFT array panel **100**, a common electrode panel **200**, and a LC layer **3** interposed between the panels **100** and **200** and containing a plurality of LC molecules aligned vertical to surfaces of the panels **100** and **200**.

[0238] The TFT array panel **100** is now described in detail.

[0239] A plurality of gate lines **121** transmitting gate signals are formed on an insulating substrate **110**.

[0240] The gate lines **121** extend substantially in a transverse direction and they are separated from each other. Each gate line **121** includes a plurality of projections forming a plurality of gate electrodes **124** and an end portion having a larger width for connection with an external driving circuit.

[0241] The gate lines **121** is preferably made of Al containing metal such as Al and Al alloy, Ag containing metal such as Ag and Ag alloy, Cu containing metal such as Cu and Cu alloy, Mo containing metal such as Mo and Mo alloy, Cr, Ti or Ta. The gate lines **121** may have a multi-layered structure including two films having different physical characteristics.

[0242] In addition, the lateral sides of the gate lines **121** are inclined relative to a surface of the substrate **110**, and the inclination angle thereof ranges about 20-80 degrees.

[0243] A gate insulating layer **140** preferably made of silicon nitride (SiNx) is formed on the gate lines **121**.

[0244] A plurality of semiconductor stripes **151** preferably made of hydrogenated amorphous silicon (abbreviated to "a-Si") are formed on the gate insulating layer **140**. Each

semiconductor stripe **151** extends substantially in the longitudinal direction and has a plurality of projections **154** branched out toward the gate electrodes **124**. The width of each semiconductor stripe **151** becomes large near the gate lines **121** such that the semiconductor stripe **151** covers large areas of the gate lines **121**.

[0245] A plurality of ohmic contact stripes and islands **161** and **165** preferably made of silicide or n+ hydrogenated a-Si heavily doped with n type impurity such as phosphorous are formed on the semiconductor stripes **151**. Each ohmic contact stripe **161** has a plurality of projections **163**, and the projections **163** and the ohmic contact islands **165** are located in pairs on the projections **154** of the semiconductor stripes **151**.

[0246] The lateral sides of the semiconductor stripes **151** and the ohmic contacts **161** and **165** are tapered, and the inclination angles thereof are preferably in a range between about 30-80 degrees.

[0247] A plurality of data lines **171** and a plurality of drain electrodes **175** separated from the data lines **171** are formed on the ohmic contacts **161** and **165** and the gate insulating layer **140**.

[0248] The data lines **171** for transmitting data voltages extend substantially in the longitudinal direction and intersect the gate lines **121**. Each data line **171** includes an end portion **179** having wider width for contact with another layer or an external device. A plurality of branches of each data line **171**, which project toward the drain electrodes **175**, form a plurality of source electrodes **173**. Each drain electrode **175** obliquely extends from a position near the source electrode **173** to have an end portion having a rectangular shape. Each source electrode **173** is curved to partly enclose an end portion of the drain electrode **175**. A gate electrode **124**, a source electrode **173**, and a drain electrode **175** along with a projection **154** of a semiconductor stripe **151** form a TFT having a channel formed in the projection **154** disposed between the source electrode **173** and the drain electrode **175**.

[0249] The data lines **171** and the drain electrodes **175** are preferably made of refractory metal such as Mo containing metal, Cr or Al containing metal and they may also include a lower film (not shown) preferably made of Mo, Mo alloy or Cr and an upper film (not shown) located thereon and preferably made of Al containing metal.

[0250] Like the gate lines **121**, the data lines **171** and the drain electrodes **175** have inclined lateral sides, and the inclination angles thereof range about 30-80 degrees.

[0251] The ohmic contacts **161** and **165** are interposed only between the underlying semiconductor stripes **151** and the overlying data lines **171** and the overlying drain electrodes **175** thereon and reduce the contact resistance therebetween. The semiconductor stripes **151** include a plurality of exposed portions, which are not covered with the data lines **171** and the drain electrodes **175**, such as portions located between the source electrodes **173** and the drain electrodes **175**. Although the semiconductor stripes **151** are narrower than the data lines **171** at most places, the width of the semiconductor stripes **151** becomes large near the gate lines **121** as described above, to smooth the profile of the surface, thereby preventing the disconnection of the data lines **171**.

[0252] A passivation layer **180** is formed on the data lines **171**, the drain electrodes **175**, and the exposed portions of the semiconductor stripes **151**. The passivation layer **180** is preferably made of photosensitive organic material having a good flatness characteristic, low dielectric insulating material having dielectric constant lower than 4.0 such as a-Si:C:O and a-Si:O:F formed by plasma enhanced chemical vapor deposition (PECVD), or inorganic material such as silicon nitride.

[0253] The passivation layer **180** has a plurality of contact holes **181** exposing the expansions of the drain electrodes **175**.

[0254] A plurality of pixel electrodes **190** which are preferably made of ITO or IZO, are formed on the passivation layer **180**. However, they may be made of reflective metal when the LCD is a reflective LCD.

[0255] The pixel electrodes **190** are physically and electrically connected to the drain electrodes **175** through the contact holes **181** such that the pixel electrodes **190** receive the data voltages from the drain electrodes **175**.

[0256] Corners of each pixel electrode **190** are chamfered to form chamfered edges that preferably make an angle of about 45 degrees with the gate lines **121**.

[0257] Each pixel electrode **190** has a transverse cutout **92** extending in the transverse direction and located at a position so as to partition the pixel electrode **190** into upper and lower halves arranged in the longitudinal direction, and a pair of oblique cutouts **91** and **93** extending in oblique directions and located respectively in the lower and the upper halves of the pixel electrodes **190**. The cutouts **91-93** start from a right edge of the pixel electrode **190** and extend toward a left edge of the pixel electrode **190**. The transverse cutout **92** ends near a center of the pixel electrode **190** and it has a chamfered inlet. The oblique cutouts **91** and **93** ends near the left edge of the pixel electrode **190**. The extensions of the oblique cutouts **91** and **93** are preferably perpendicular to each other in order for regularly distributing the field directions of the fringe fields into four directions. The oblique cutouts **91** and **93** are arranged symmetrical with respect to the transverse cutout **92**. The oblique cutouts **91** and **93** preferably make an angle of about 45 degrees to the gate lines **121**.

[0258] Accordingly, the upper half of the pixel electrode **190** is partitioned into two upper partitions by the oblique cutout **93**, and the lower half of the pixel electrode **190** is also partitioned into two lower partitions by the oblique cutouts **91**.

[0259] Furthermore, a plurality of protrusions **280a** are formed on the passivation layer **180** and disposed substantially in the cutouts **280a**.

[0260] An alignment layer **11** is formed on the pixel electrodes **190** and the protrusions **280a**.

[0261] The description of the common electrode panel **200** follows.

[0262] A black matrix **220** for preventing light leakage is formed on an insulating substrate **210** such as transparent glass.

[0263] A plurality of red, green and blue color filters **230R**, **230G** and **230B** are formed substantially in open areas of the black matrix **220** and an overcoat **250** is formed on the color filters **230**.

[0264] A common electrode **270** preferably made of transparent conductive material such as ITO and IZO is formed on the overcoat **250**.

[0265] The common electrode **270** has a plurality of sets of cutouts **271-273**. Two adjacent cutouts **271**, **272** and **273** of the common electrode **270** interpose the oblique cutouts **91** and **93** of the pixel electrode **190**.

[0266] In addition, a plurality of sets of protrusions **280b** are formed on the overcoat **250** and disposed substantially in the cutouts **271-273**.

[0267] The cutouts **271**, **272** and **273** of the common electrode **270** opposite each other with respect to a boundary line between two adjacent pixel areas (i.e., a line extending along the data line) have substantially inversion symmetry with respect to the boundary line.

[0268] The cutouts **272** and **273** include oblique portions extending substantially parallel to the oblique cutouts **91** and **93** and transverse and longitudinal portions connected to ends of the oblique portions, overlapping the edges of the pixel electrodes **190**, and making an obtuse angle with the oblique portions. The cutout **271** includes a pair of oblique portions meeting near the center of the pixel electrode **190**, a central transverse portion extending from the meeting point to a longitudinal edge of the pixel electrode **190** with making an obtuse angle with the oblique portions, and a pair of terminal transverse portions extending from the ends of the oblique portions along the longitudinal edge of the pixel electrode **190** with making an obtuse angle with the oblique portions. The cutouts **271-273** are disposed between the cutouts **91-93** and the chamfered edges of the pixel electrode **190** and the distances between the oblique portions of adjacent cutouts **271-273** and **91-93** and the distances between the oblique portions of the cutouts **272** and **273** and the chamfered edges of the pixel electrode **190** are substantially the same.

[0269] A homeotropic alignment layer **21** is coated on the common electrode **270** and the protrusions **280b**, and a pair of polarizers (not shown) are provided on outer surfaces of the panels **100** and **200** such that their polarization axes are crossed and one of the transmissive axes is parallel to the gate lines **121**. One of the polarizers may be omitted when the LCD is a reflective LCD.

[0270] The LCD may further include at least one retardation film for compensating the retardation of the LC layer **3**.

[0271] The LC molecules in the LC layer **3** are aligned such that their long axes are vertical to the surfaces of the panels **100** and **200**. The liquid crystal layer **3** has negative dielectric anisotropy.

[0272] The cutouts **91-93** and **271-273** as well as the protrusions **280a** and **280b** controls the tilt directions of the LC molecules in the LC layer **3**. That is, the liquid crystal molecules in each region called domain defined by adjacent cutouts **91-93** and **271-273** or by the cutout **272** or **273** and the chamfered edge of the pixel electrode **190** are tilted in a direction perpendicular to the extension direction of the cutouts **91-93** and **271-273**. It is apparent that the domains have two long edges extending substantially parallel to each other and making an angle of about 45 degrees with the gate line **121**.

[0273] The expansions of the drain electrodes 175 are disposed near corners of the domains to block the light leakage or the texture generated near the corners due to the disorder of the orientations of the LC molecules.

[0274] An LCD according to another embodiment of the present invention will be described in detail with reference to FIGS. 37 and 38.

[0275] FIG. 37 is a layout view of an LCD according to another embodiment of the present invention, and FIG. 38 is a sectional view of the LCD shown in FIG. 37 taken along the line XXXVII-XXXVII'.

[0276] Referring to FIGS. 37 and 38, an LCD according to this embodiment also includes a TFT array panel 100, a common electrode panel 200, and a LC layer 3 interposed therebetween.

[0277] Layered structures of the panels 100 and 200 according to this embodiment are almost the same as those shown in FIGS. 32-36.

[0278] Regarding the TFT array panel 100, a plurality of gate lines 121 including a plurality of gate electrodes 124 and a plurality of storage electrode lines 131 including a plurality of storage electrodes 133 are formed on a substrate 110, and a gate insulating layer 140, a plurality of semiconductor stripes 151 including a plurality of projections 154, and a plurality of ohmic contact stripes 161 including a plurality of projections 163 and a plurality of ohmic contact islands 165 are sequentially formed thereon. A plurality of data lines 171 including a plurality of source electrodes 173 and a plurality of drain electrodes 175 are formed on the ohmic contacts 161 and 165, and a passivation layer 180 is formed thereon. A plurality of contact holes 183 are provided at the passivation layer 180 and the gate insulating layer 140, and a plurality of protrusions 280a are formed on the passivation layer 180. A plurality of pixel electrodes 190 and a plurality of contact assistants 81 and 82 are formed on the passivation layer 180 and an alignment layer 11 is formed thereon.

[0279] Regarding the common electrode panel 200, a light blocking member 220, a plurality of color filters 230R, 230G and 230B, an overcoat 250, a common electrode 270, a plurality of protrusions 280b, and an alignment layer 21 are formed on an insulating substrate 210.

[0280] Different from the LCD shown in FIGS. 32-36, the semiconductor stripes 151 have almost the same planar shapes as the data lines 171 and the drain electrodes 175 as well as the underlying ohmic contacts 161 and 165. However, the projections 154 of the semiconductor stripes 151 include some exposed portions, which are not covered with the data lines 171 and the drain electrodes 175, such as portions located between the source electrodes 173 and the drain electrodes 175.

[0281] Many of the above-described features of the LCD shown in FIGS. 32-36 may be appropriate to the LCD shown in FIGS. 37 and 38.

[0282] An LCD according to another embodiment of the present invention will be described in detail with reference to FIG. 39.

[0283] FIG. 39 is a sectional view of the LCD shown in FIG. 32 taken along the line XXXIII-XXXIII' according to an embodiment of the present invention.

[0284] Referring to FIG. 39, an LCD according to this embodiment also includes a TFT array panel 100, a common electrode panel 200, and a LC layer 3 interposed therebetween.

[0285] Regarding a TFT array panel 100, a plurality of gate lines 121 including a plurality of gate electrodes 124 and a plurality of storage electrode lines 131 including a plurality of storage electrodes 133 are formed on a substrate 110, and a gate insulating layer 140, a plurality of semiconductor stripes 151 including a plurality of projections 154, and a plurality of ohmic contact stripes 161 including a plurality of projections 163 and a plurality of ohmic contact islands 165 are sequentially formed thereon. A plurality of data lines 171 including a plurality of source electrodes 173 and a plurality of drain electrodes 175 are formed on the ohmic contacts 161 and 165 and the gate insulating layer 140.

[0286] A first passivation layer 801 preferably made of inorganic insulator such as SiNx is formed on the data lines 171 and the drain electrodes 175.

[0287] A plurality of red, green and blue color filters 230R, 230G and 230B is formed on the first passivation layer 801.

[0288] A second passivation layer 802 preferably made of photosensitive organic material is formed on the color filters 230R, 230G and 230B. The second passivation layer 802 also forms hills when running over the hills formed by the color filters 230R, 230G and 230B and the hills of the second passivation layer 802 enhance the control of the tilt directions of LC molecules in the LC layer 3. The second passivation layer 802 prevents the color filters 230R, 230G and 230B from contaminating the common electrode 270 to contaminate the LC layer 3 and it may be made of inorganic insulator such as SiNx and SiO<sub>2</sub>.

[0289] A plurality of protrusions 280 are formed on the second passivation layer 802.

[0290] A plurality of pixel electrodes 190 are formed on the second passivation layer 802 and an alignment layer 11 is formed thereon.

[0291] The common electrode panel 200 includes a light blocking member 220, a common electrode 270, and an alignment layer 21 formed on an insulating substrate 210. Comparing the common electrode panel 200 shown in FIG. 8, the common electrode panel 200 shown in FIG. 39 has no color filter and no overcoat.

[0292] Since the color filters 230R, 230G and 230B and the pixel electrodes 190 are provided on the TFT array panel 100, the LCD shown in FIGS. 16-18 may have a large alignment margin for aligning the TFT array panel 100 and the common electrode panel 200.

[0293] As described above, the protrusions are disposed on the data lines to decrease parasitic capacitances generated by the data lines. Furthermore, since the protrusions and the cutouts are disposed on the same plane, the fringe field for tilting the LC molecules is enhanced and thus the width of the cutouts can be reduced to increase the aperture ratio.

[0294] The protrusions 280 may be formed along with a plurality of column spacers to simplify the manufacturing process.

[0295] While the present invention has been described in detail with reference to the preferred embodiments, those skilled in the art will appreciate that various modifications and substitutions can be made thereto without departing from the spirit and scope of the present invention as set forth in the appended claims.

[0296] For example, the arrangements of the cutouts of the pixel electrodes and the common electrode may be modified and protrusions are provided instead of the cutouts.

What is claimed is:

1. A thin film transistor array panel comprising:
  - a substrate;
  - a gate line formed on the substrate and including a gate electrode;
  - a gate insulating layer formed on the gate line;
  - a semiconductor layer formed on the gate insulating layer;
  - a data line formed at least in part on the semiconductor layer;
  - a drain electrode formed on the semiconductor layer at least in part and separated from the data line;
  - a first passivation layer formed on the data line and the drain electrode;
  - a first protrusion formed on the first passivation layer and disposed opposite the data line; and
  - a pixel electrode formed on the first passivation layer and connected to the drain electrode.
2. The thin film transistor array panel of claim 1, wherein the pixel electrode has a cutout.
3. The thin film transistor array panel of claim 2, further comprising a second protrusion disposed in the cutout.
4. The thin film transistor array panel of claim 2, further comprising a storage electrode line overlapping the pixel electrode.
5. The thin film transistor array panel of claim 4, wherein the storage electrode line comprises an expansion overlapping the drain electrode.
6. The thin film transistor array panel of claim 4, wherein the storage electrode line comprises a branch overlapping the cutout.
7. The thin film transistor array panel of claim 1, wherein the first protrusion is wider than the data line.
8. The thin film transistor array panel of claim 1, wherein the data line is curved.
9. The thin film transistor array panel of claim 1, further comprising a spacer having a height larger than the first protrusion and disposed on the same layer as the first protrusion.
10. The thin film transistor array panel of claim 9, wherein the first protrusion and the spacer comprise organic material.
11. The thin film transistor array panel of claim 1, further comprising a color filter disposed between the first passivation layer and the first protrusion and the pixel electrode.
12. The thin film transistor array panel of claim 11, further comprising a second passivation layer formed on the color filter and the first protrusion and the pixel electrode.
13. The thin film transistor array panel of claim 1, wherein the semiconductor layer has substantially the same planar shape as the data line and the drain electrode.

14. A thin film transistor array panel comprising:

- a substrate;
- a gate line formed on the substrate and including a gate electrode;
- a gate insulating layer formed on the gate line;
- a semiconductor layer formed on the gate insulating layer;
- a data line formed at least in part on the semiconductor layer;
- a drain electrode formed on the semiconductor layer at least in part and separated from the data line;
- a first passivation layer formed on the data line and the drain electrode and having a contact hole exposing the drain electrode at least in part;
- a pixel electrode formed on the first passivation layer and connected to the drain electrode through the contact hole; and
- a protrusion formed on the first passivation layer and disposed in the cutout at least in part.

15. The thin film transistor array panel of claim 14, further comprising a storage electrode line overlapping the pixel electrode.

16. The thin film transistor array panel of claim 15, wherein the storage electrode line comprises an expansion overlapping the drain electrode.

17. The thin film transistor array panel of claim 15, wherein the storage electrode line comprises a branch overlapping the cutout.

18. The thin film transistor array panel of claim 14, wherein the data line is curved.

19. The thin film transistor array panel of claim 14, further comprising a spacer having a height larger than the protrusion and disposed on the same layer as the protrusion.

20. The thin film transistor array panel of claim 19, wherein the protrusion and the spacer comprise organic material.

21. The thin film transistor array panel of claim 14, further comprising a color filter disposed between the first passivation layer and the protrusion and the pixel electrode.

22. The thin film transistor array panel of claim 21, further comprising a second passivation layer formed on the color filter and the protrusion and the pixel electrode.

23. The thin film transistor array panel of claim 1, wherein the semiconductor layer has substantially the same planar shape as the data line and the drain electrode.

24. A liquid crystal display comprising:

- a first substrate;
- a gate line formed on the first substrate;
- a data line intersecting the gate line;
- a thin film transistor connected to the gate line and the data line;
- a pixel electrode connected to the thin film transistor and having a first cutout;
- a second substrate facing the first substrate;
- a common electrode formed on the second substrate and having a second cutout; and



a first protrusion disposed in at least one of the first and the second cutouts at least in part.

**25.** The liquid crystal display of claim 24, further comprising:

a light blocking member disposed on one of the first and the second substrates; and

a color filter disposed on one of the first and the second substrates.

**26.** The liquid crystal display of claim 24, further comprising a second protrusion disposed on the data line.

**27.** The liquid crystal display of claim 24, wherein the first cutout does not overlap the second cutout.

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|                |                                                                   |         |            |
|----------------|-------------------------------------------------------------------|---------|------------|
| 专利名称(译)        | 液晶显示器及其薄膜晶体管阵列面板                                                  |         |            |
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| 其他公开文献         | US7755734                                                         |         |            |
| 外部链接           | <a href="#">Espacenet</a> <a href="#">USPTO</a>                   |         |            |

#### 摘要(译)

在基板上形成沿横向延伸的栅极线和与栅极线交叉的数据线。通过薄膜晶体管连接到栅极线和数据线的像素电极形成在绝缘层上。像素电极具有切口，并且突出部设置在切口中。另一个突起设置在数据线上。

